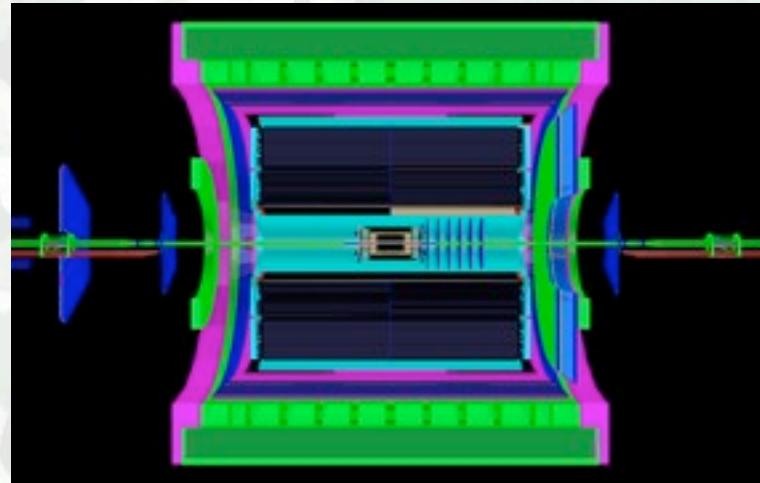




# The STAR Forward GEM Tracker (FGT)

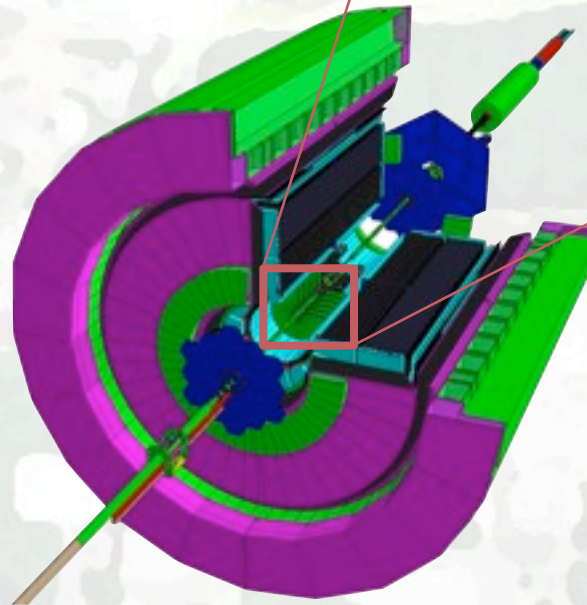
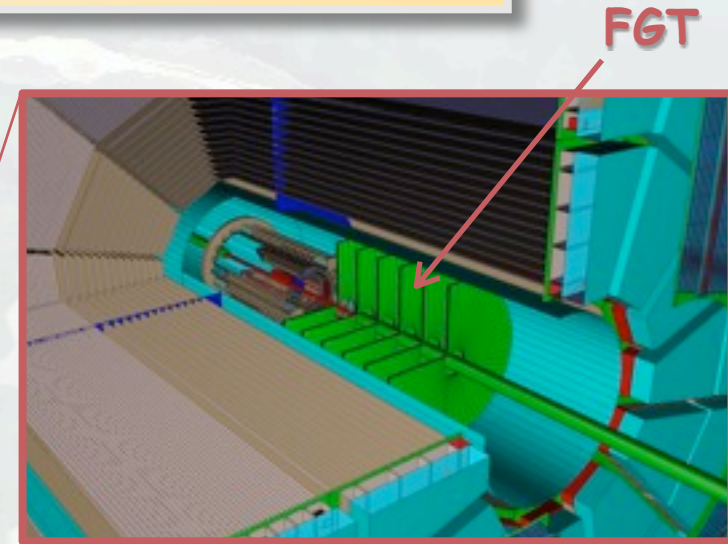
Bernd Surrow





# Outline

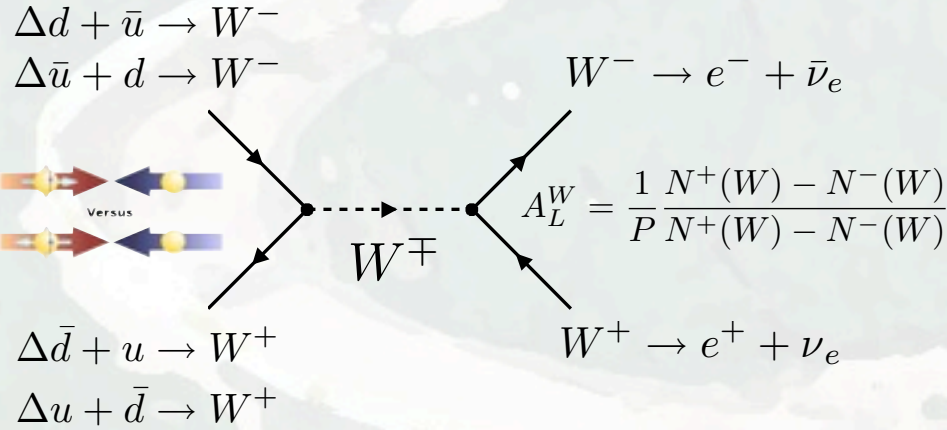
- **FGT** Physics motivation - W program
- **FGT** Layout - Simulation results and optimization
- **FGT** Technical Realization
  - Triple-GEM detector development - R&D
  - Mechanical design
  - Front-End Electronics
  - DAQ
- **FGT** Schedule / Milestones
- Summary



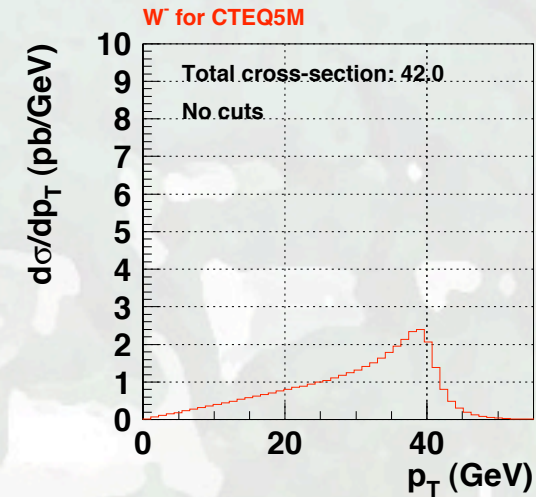
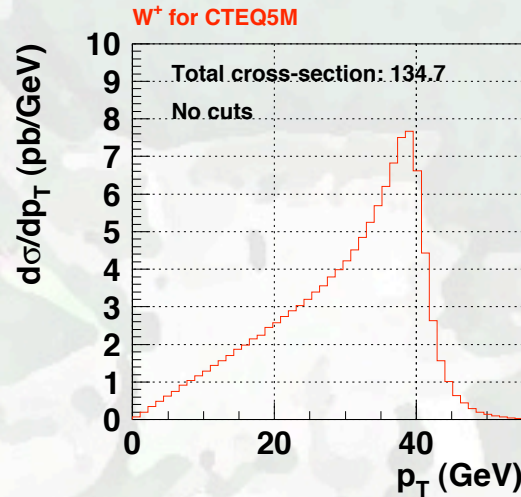
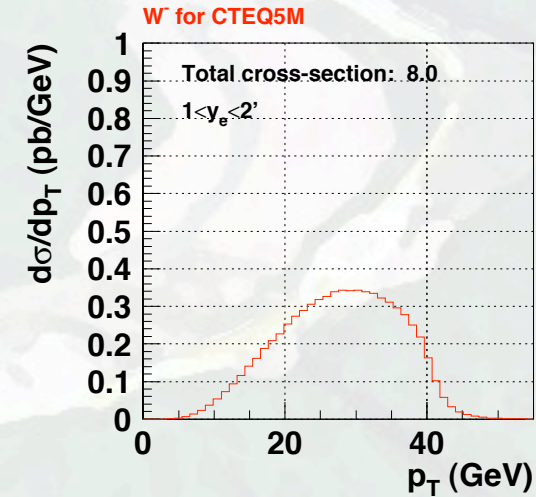
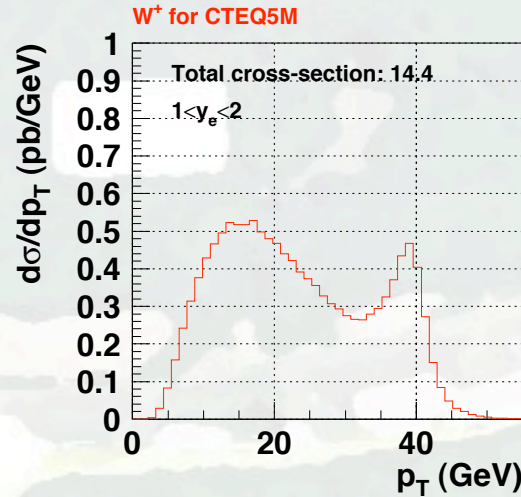


# FGT Physics motivation - W program

## Quark / Anti-Quark Polarization - W production



RHICBOS W simulation at 500GeV CME

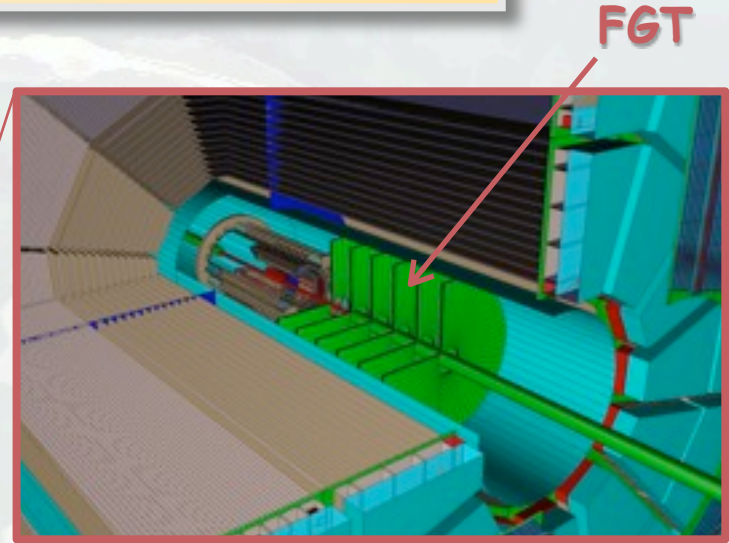
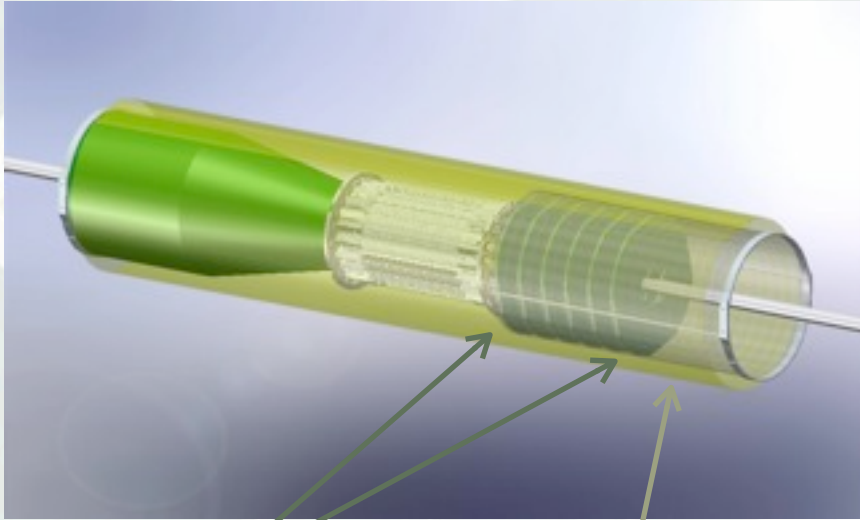


- **Key signature:** High p<sub>T</sub> lepton (e<sup>-</sup>/e<sup>+</sup> or μ<sup>-</sup>/μ<sup>+</sup>) (Max. M<sub>W</sub>/2) - Selection of W<sup>-</sup>/W<sup>+</sup>: Charge sign discrimination of high p<sub>T</sub> lepton
- **Required:** Lepton/Hadron discrimination

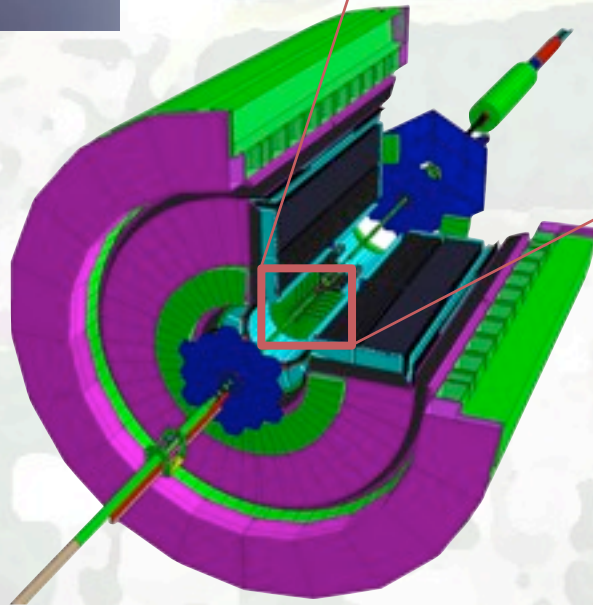


# FGT Layout - Simulation results and optimization

## Layout



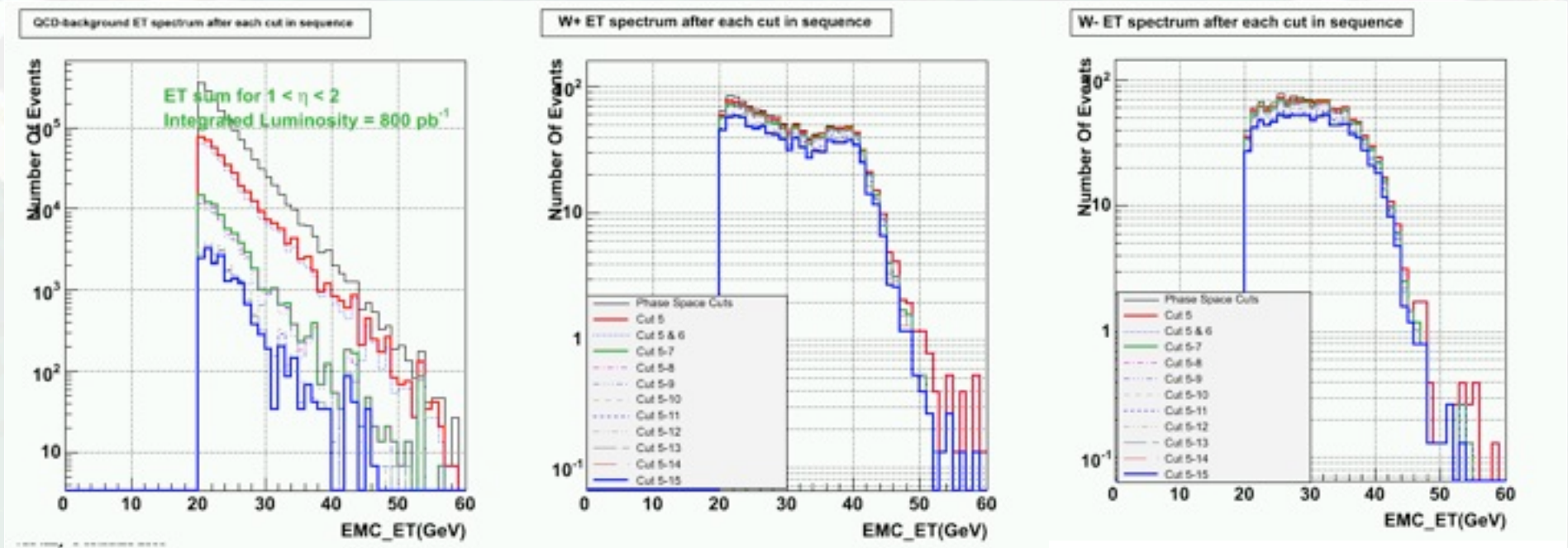
- FGT: 6 light-weight triple-GEM disks - WEST side of STAR
- New mechanical support structure





# FGT Layout - Simulation results and optimization

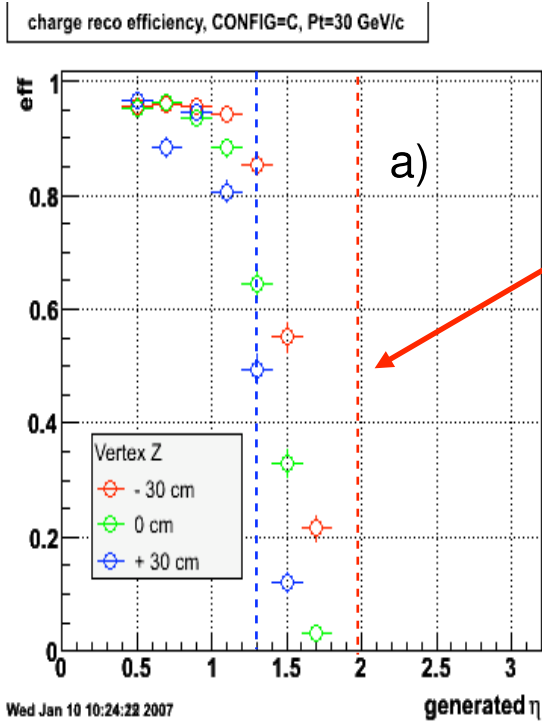
- Quark / Anti-Quark polarization program at STAR - e/h separation
  - Full PYTHIA QCD background and W signal sample including detector effects



- e/h separation based on global cuts (isolation/missing  $E_T$ ) and EMC specific cuts as
- With current algorithm:  $E_T > 25 \text{ GeV}$  yields  $S/B > 1$  (For  $E_T < 25 \text{ GeV}$   $S/B \sim 1/5$ ) used for  $A_L$  uncertainty estimates

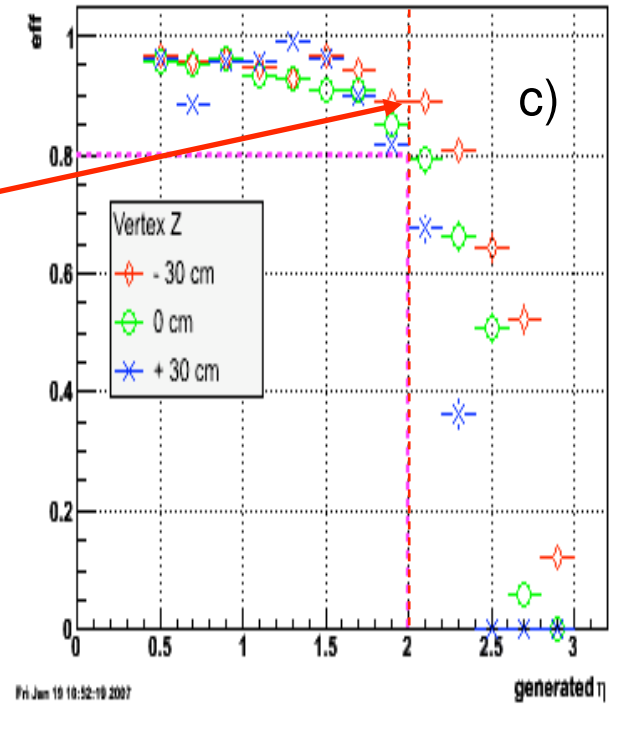
# FGT Layout - Simulation results and optimization

## Quark / Anti-Quark polarization program at STAR



Reach of EEMC Acceptance

TPC + FGT Tracking,  $p_T = 30 \text{ GeV}/c$



### Conclusion:

Charge sign reconstruction impossible beyond  $\eta = \sim 1.3$

6 triple-GEM disks, assumed spatial resolution  $60 \mu\text{m}$  in x and y (Fairly insensitive for  $60\text{-}100 \mu\text{m}$ )

Charge sign reconstruction probability above 90% for 30 GeV  $p_T$  over the full acceptance of the EEMC for the full vertex spread



# FGT Technical realization

- SBIR proposal (1)
  - SBIR: **Small Business Innovation Research: US Government (DOE) funded program**
    - ☑ Phase I: Explore feasibility of innovative concepts with award of up to \$100k
    - ☑ Phase II: Principal R&D effort with award of up to \$750k
    - Phase III: Commercial application
  - SBIR: **Collaborative effort of Tech-Etch Inc. with BNL, MIT and Yale University - Production of GEM foils**
    - Develop optimized production process for small (10cm X 10cm) and larger GEM foils
    - Investigate a variety of materials
    - Study post production handling: Cleaning, surface treatment and storage
  - **New SBIR proposal (submitted to DOE): 2D readout board using chemical etching**



# FGT Technical realization

## □ SBIR proposal (2)

### ○ Tech-Etch Inc.: Company profile

- Manufacturer of precision flexible circuits
- Extensive experience in etching of copper traces and polyamide
- Strong ties to BNL, MIT and Yale University

Tech-Etch Inc.

### ○ Critical performance parameters

- Achievable gain, gain uniformity and gain stability
- Energy resolution



<http://www.tech-etch.com>

### ○ Status

- Phase I / II approved - Dedicated production facility at Tech-Etch Inc.
- Success with 10cm X 10cm samples / First large GEM foils received





# FGT Technical realization

## □ R&D Development at MIT

### ○ Resources

- 2 dedicated clean rooms (Class ~100/1000) (MIT Bates Laboratory / MIT Laboratory for Nuclear Science)
- HV radioactive source setup / HV box / Light-microscope / Laminar flow hood / GEM foil CCD camera scanner

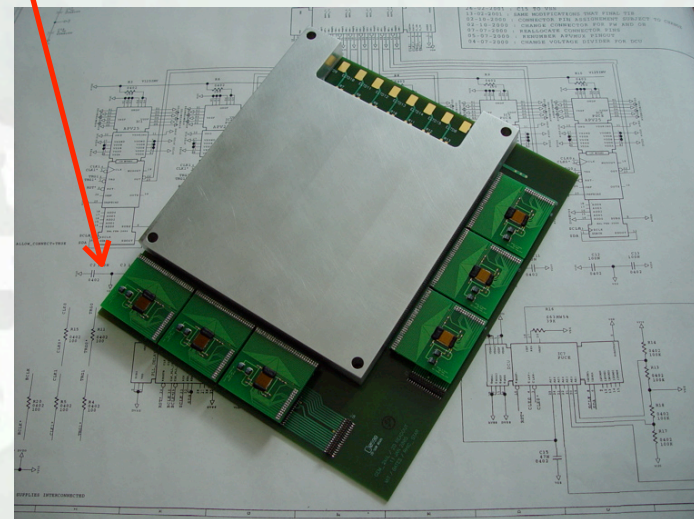
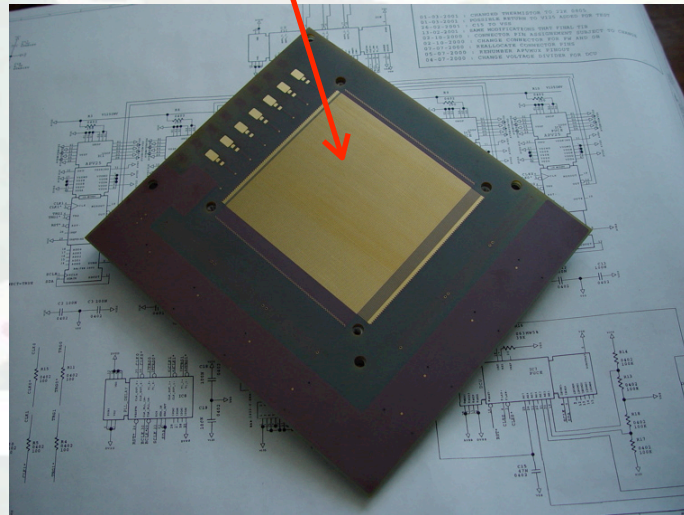
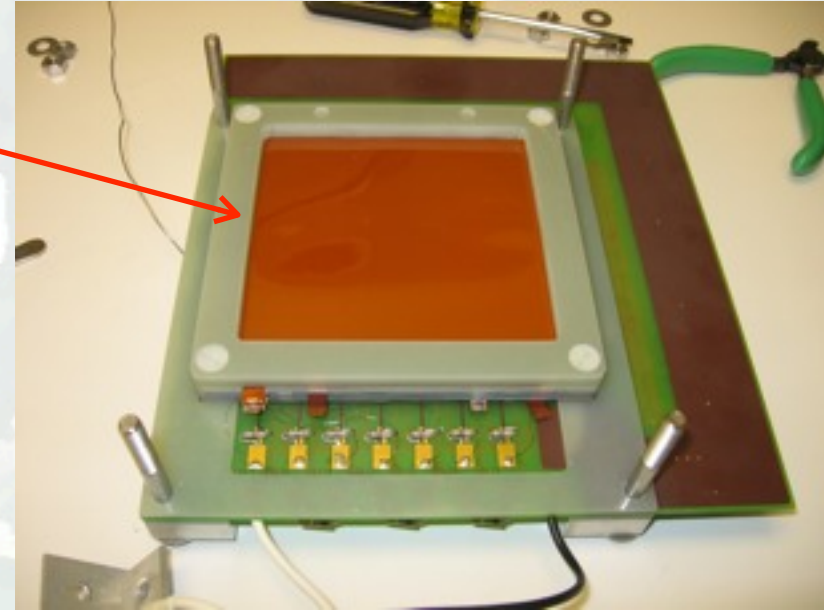
### ○ Activities based on 10cm X 10cm samples

- Dark current / resistivity tests
- Optical scans
- Sources tests and test beam experiment at FNAL

- **Publications:** 1) U. Becker et al., NIM A556 527 (2006). 2) F. Simon et al., IEEE Trans. Nucl. Sci. 54, 2646 (2007). 3) F. Simon et al., NIM A598 432 (2009).

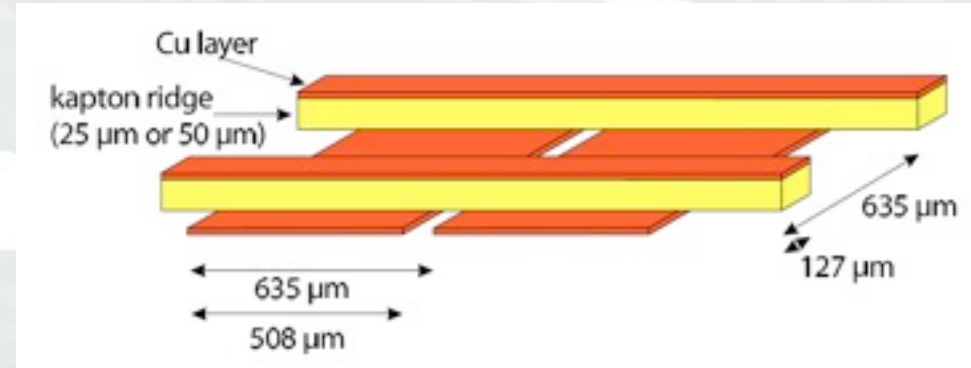
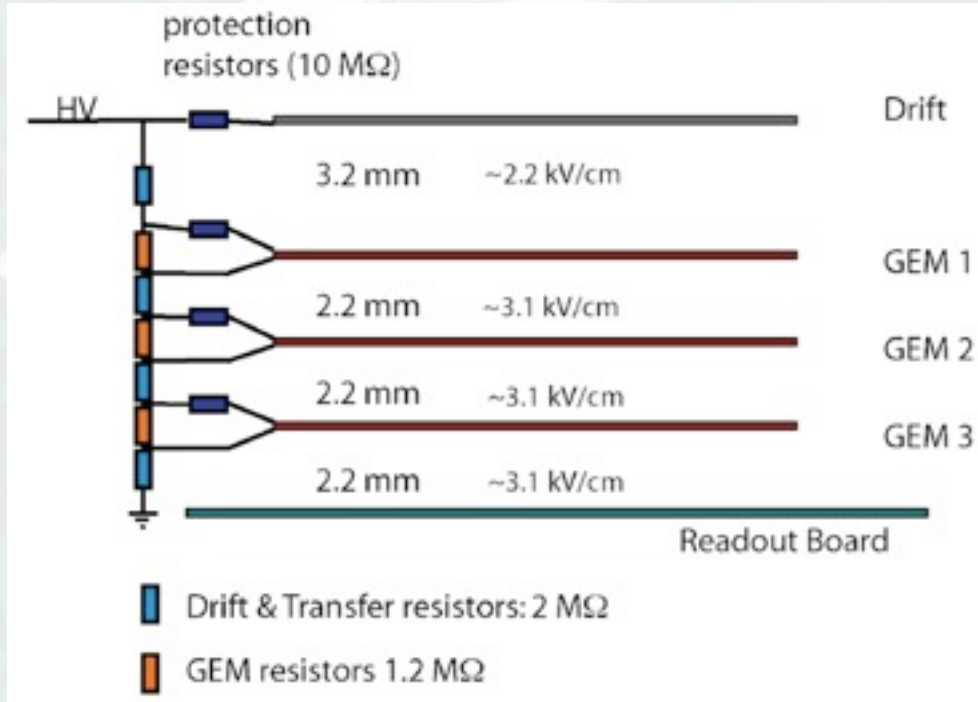
# FGT Technical realization

- Prototype triple-GEM configuration (1)
  - Prototype triple-GEM detector (Ar/CO<sub>2</sub> 70:30 gas-mixture) to allow flexible handling
  - Integrated APV25-S1 chip readout system
  - 2D projective readout board, using laser etching and micro-machining



# FGT Technical realization

## □ Prototype triple-GEM configuration (2)



- Test beam operating voltage:  $\sim$ 3750V-3800V corresponding to  $\sim$ 385V-395V per GEM foil

- Testbeam effective gain:  $\sim$ 3.5  $\cdot$  10<sup>3</sup> ( $\sim$ 2.5  $\cdot$  10<sup>4</sup> bench tests)

- Laser etched 2D readout board (Compunetics Inc.)

- Test beam configuration:

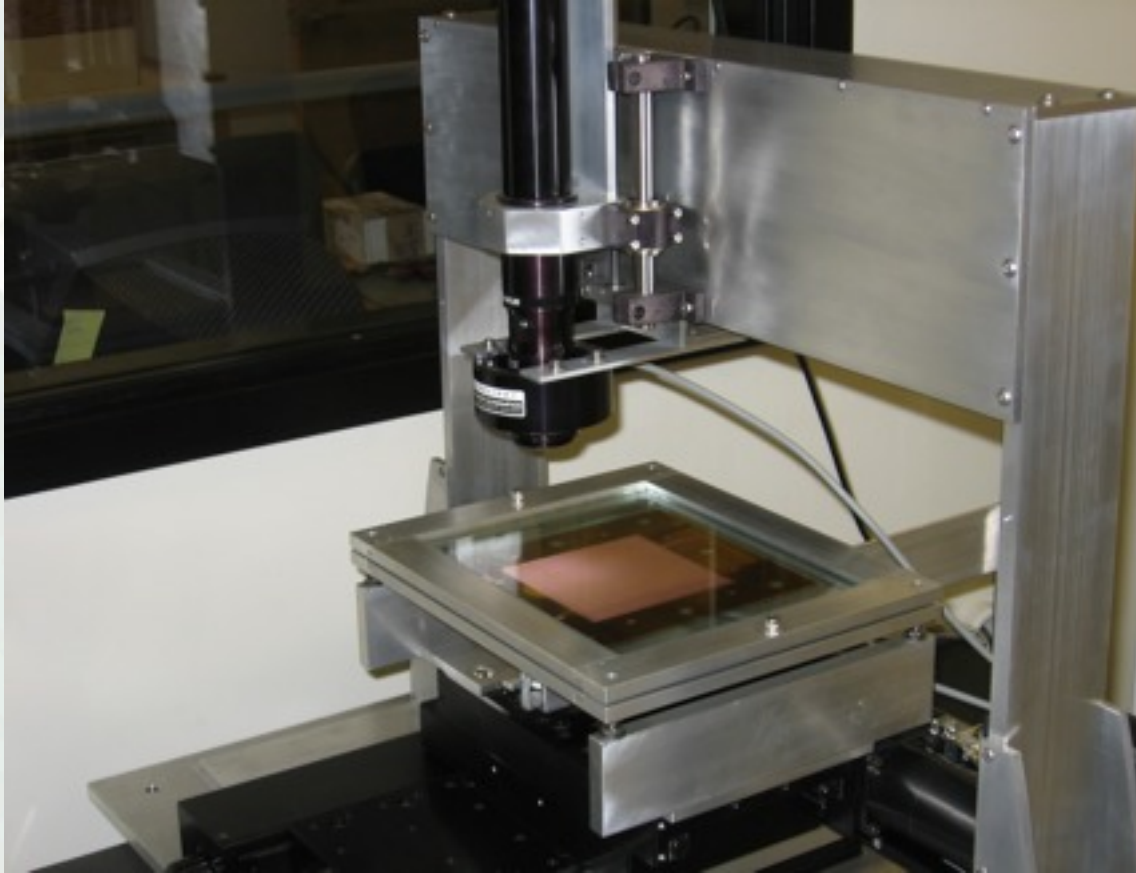
Top strips (Y):  $\sim$ 127 $\mu$ m

Bottom strips (X): 508 $\mu$ m

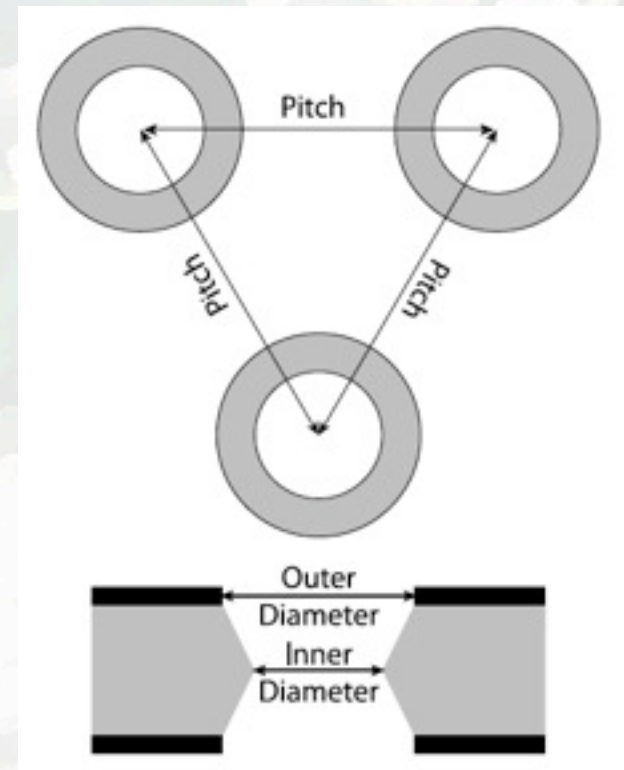
- Two separations: 25 $\mu$ m and 50 $\mu$ m

# FGT Technical realization

## □ Optical scans (1)



- 2D scanning table with CCD camera - fully automated
- Scan GEM foils to measure hole diameter (inner and outer) and pitch



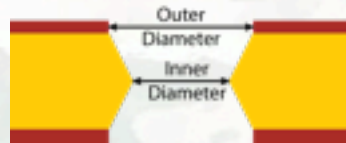
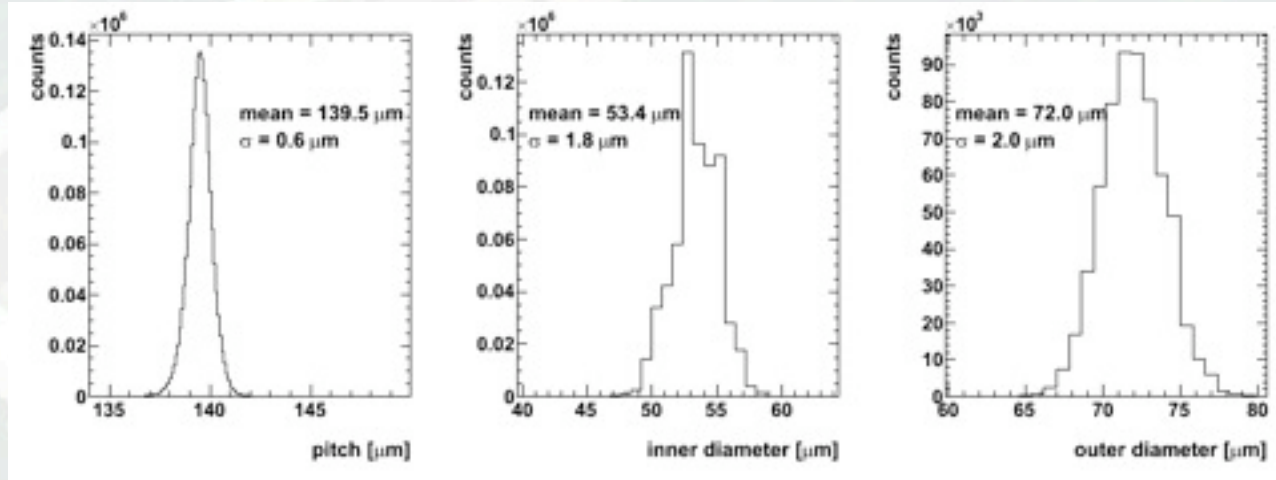
## ○ Check for defects:

- Missing holes, enlarged holes, dirt in holes and etching defects

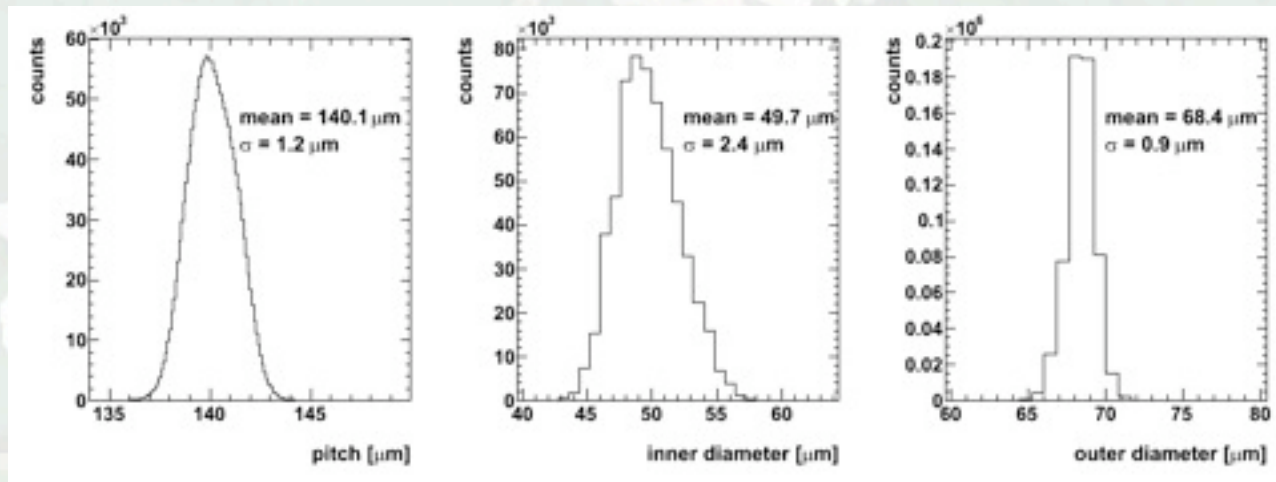
# FGT Technical realization

## □ Optical scans (2)

Tech-Etch



CERN

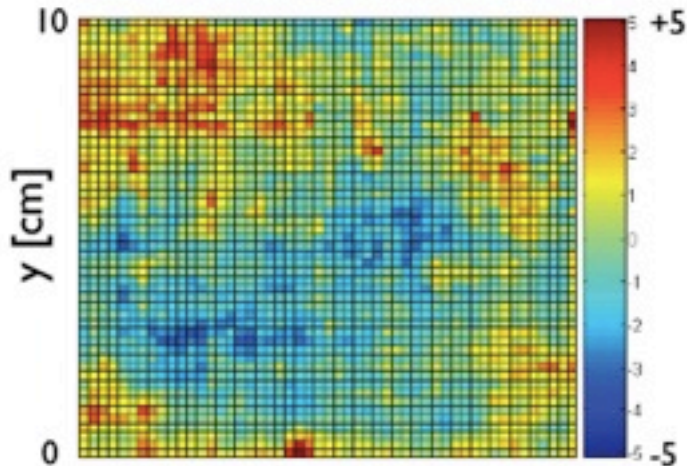


- Geometrical parameters are similar for Tech-Etch and CERN foils (10cm X 10cm samples)

# FGT Technical realization

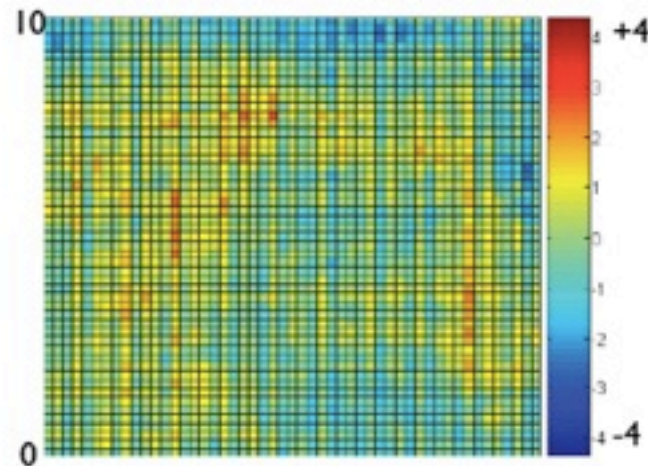
## □ Optical scans (3)

outer holes

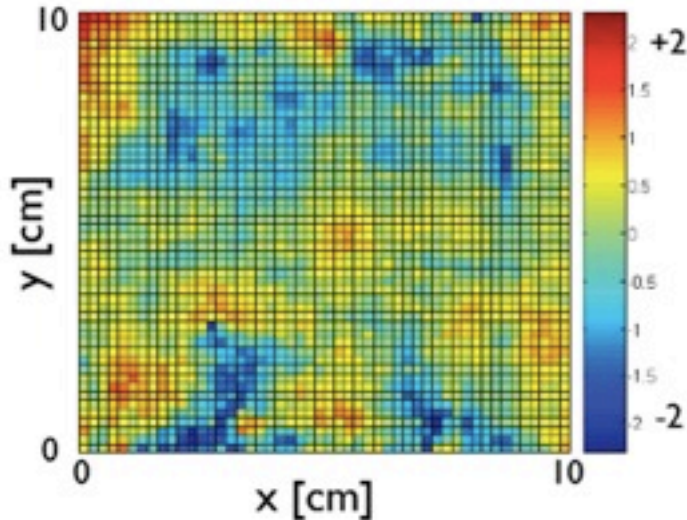


Tech-Etch

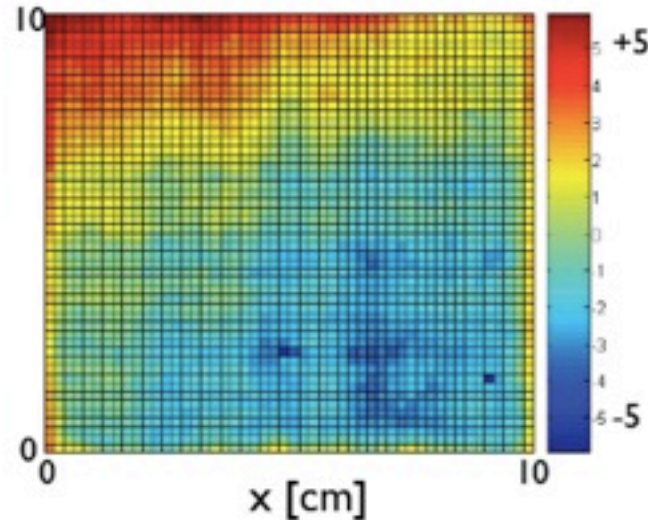
inner holes



deviation from mean [ $\mu\text{m}$ ]



CERN

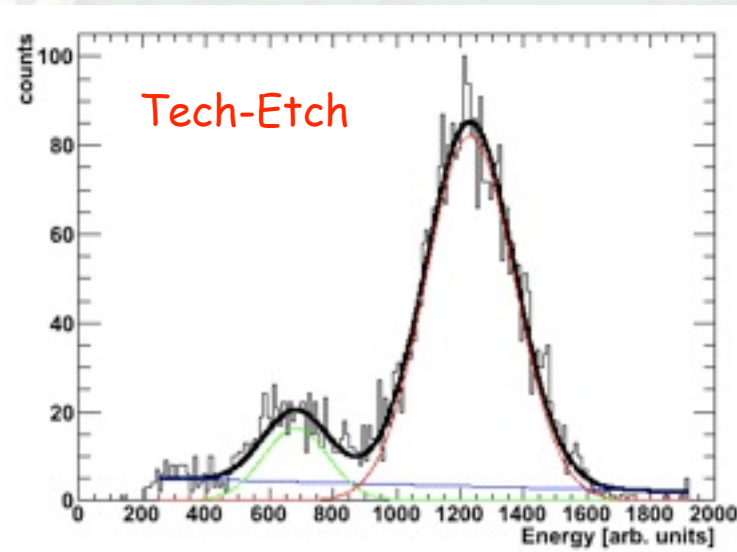
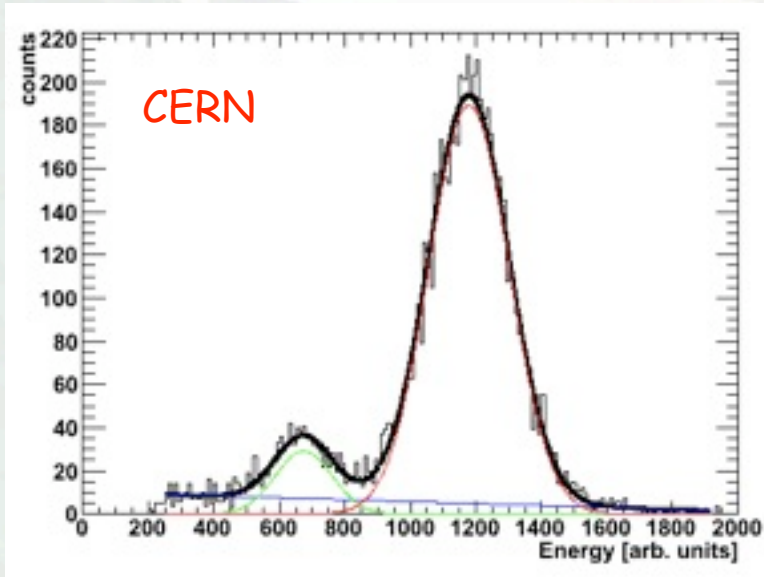


- Uniformity of outer/inner hole diameters for Tech-Etch and CERN foils (10cm X 10cm samples)

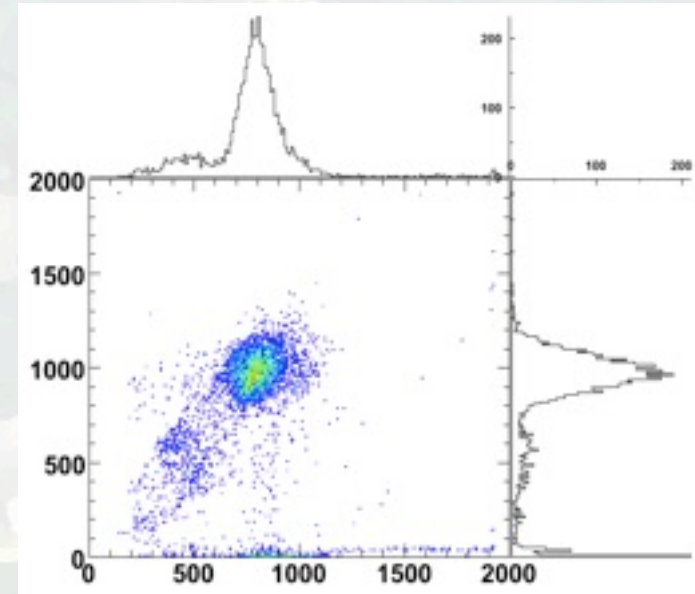


# GEM foil test results

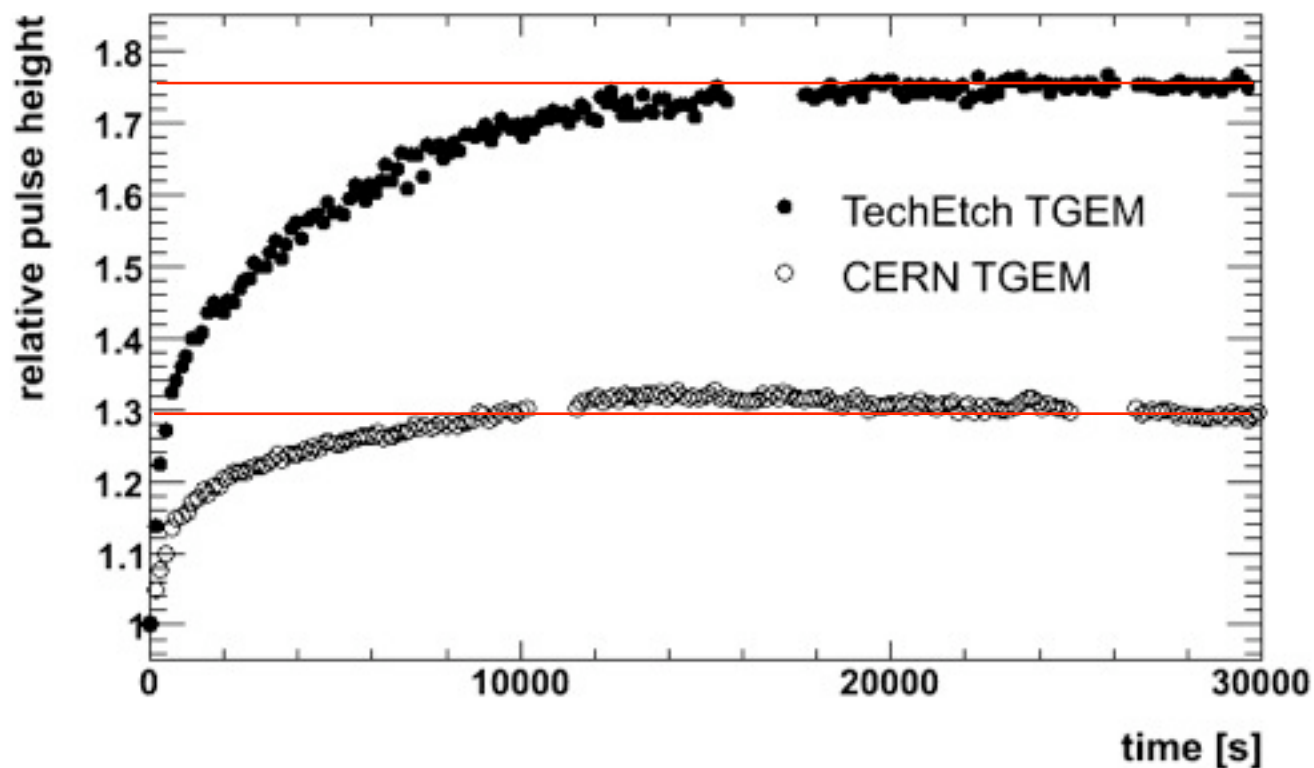
- Source tests (1)
  - Two identical detectors, one with CERN foils, one using Tech-Etch foils
  - Both detectors give reasonable X-Ray spectrum using  $^{55}\text{Fe}$  source with comparable energy resolution ( $\sim 20\%$ )



Correlation  
of X-Y  
readout  
plane



## □ Source tests (2)

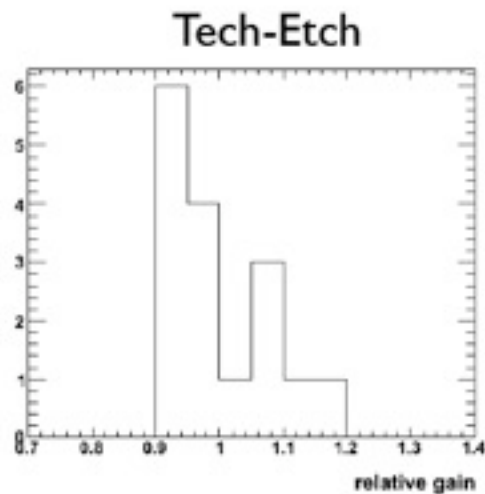
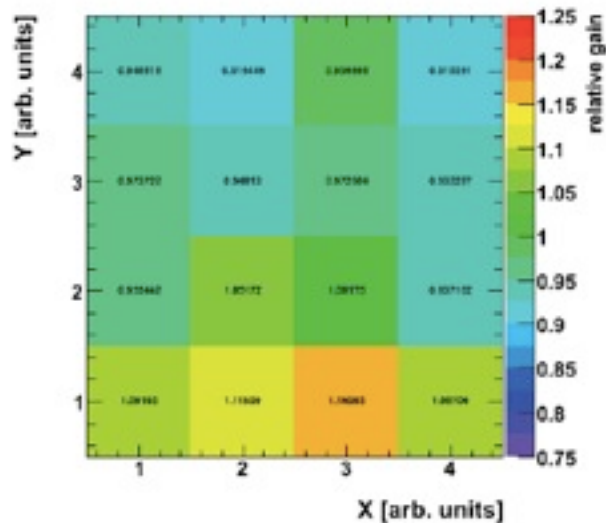
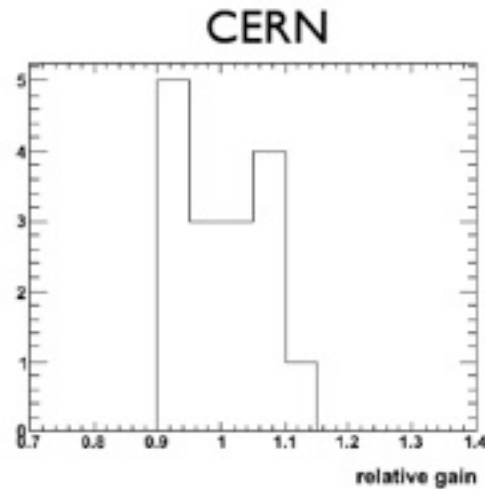
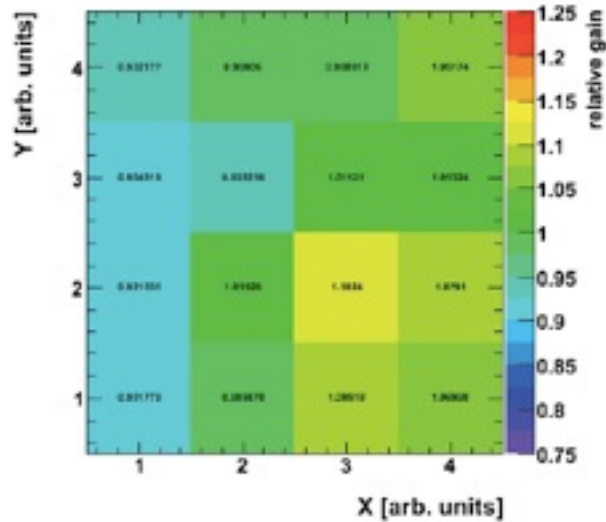


- Evolution of relative gain for Tech-Etch and CERN GEM foil based triple-GEM prototype detector as a function of time
- Irradiation: Low intensity  $^{55}\text{Fe}$  source ( $\sim 0.5\text{Hz}/\text{mm}^2$ )



# FGT Technical realization

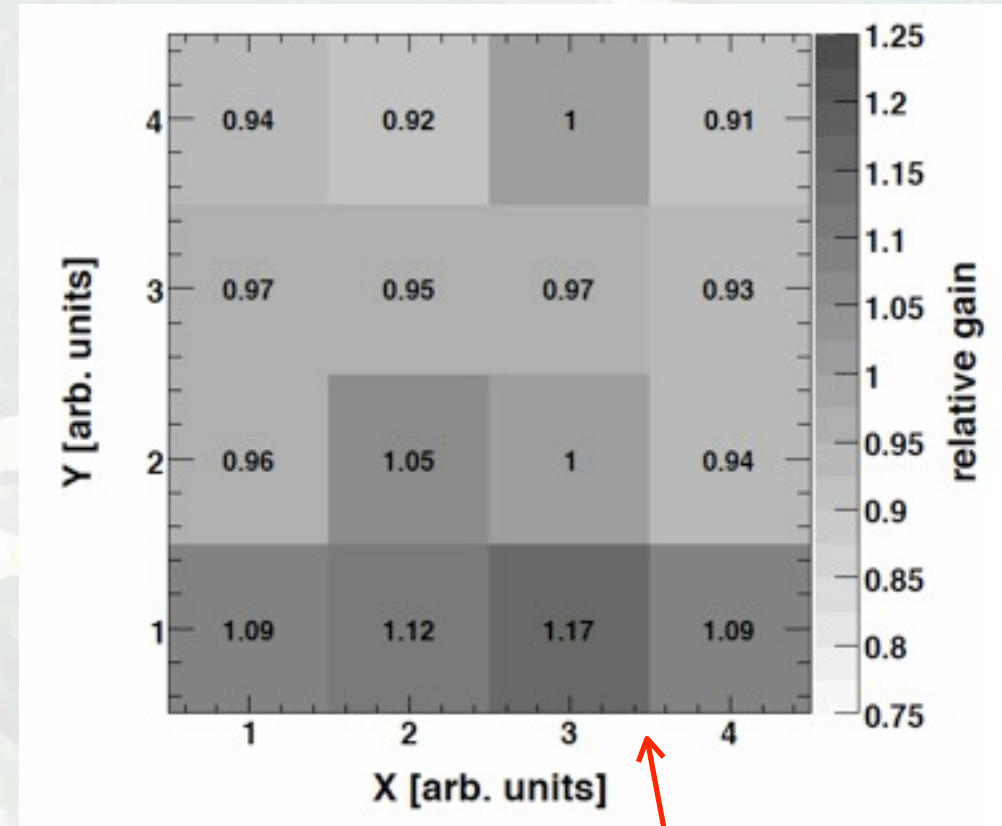
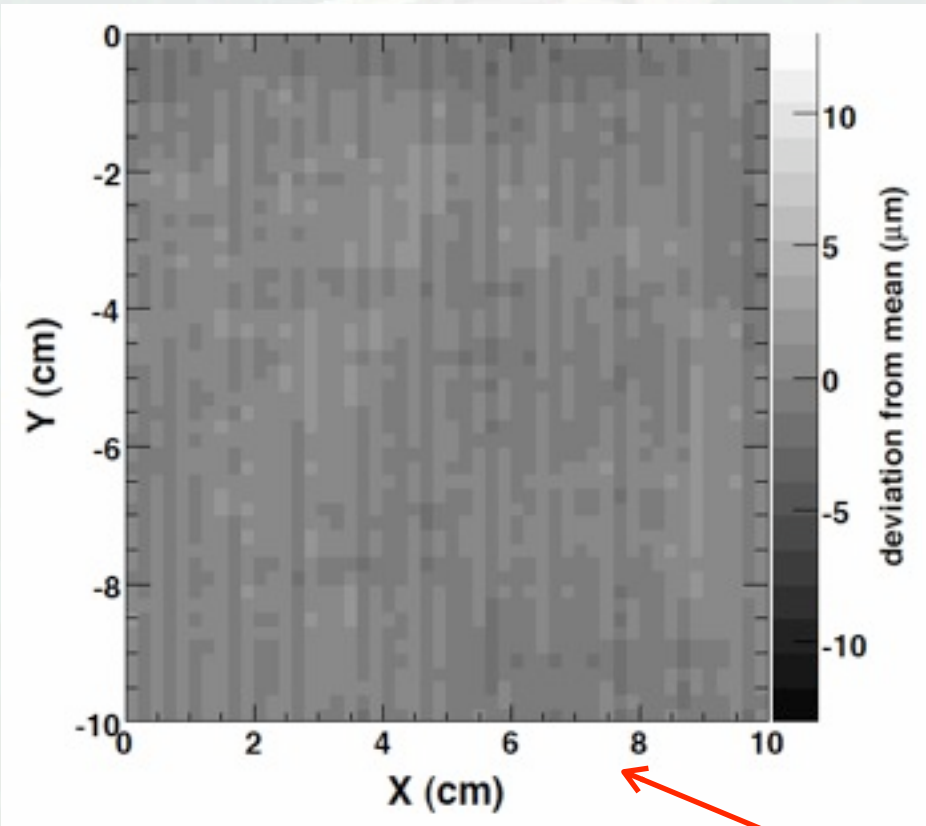
## □ Source tests (3)



- Gain measured with low intensity  $^{55}\text{Fe}$  source ( $\sim 0.5\text{Hz}/\text{mm}^2$ )
- Good gain uniformity over full active area (Measured after charge built-up)

# FGT Technical realization

## □ Source tests (4)

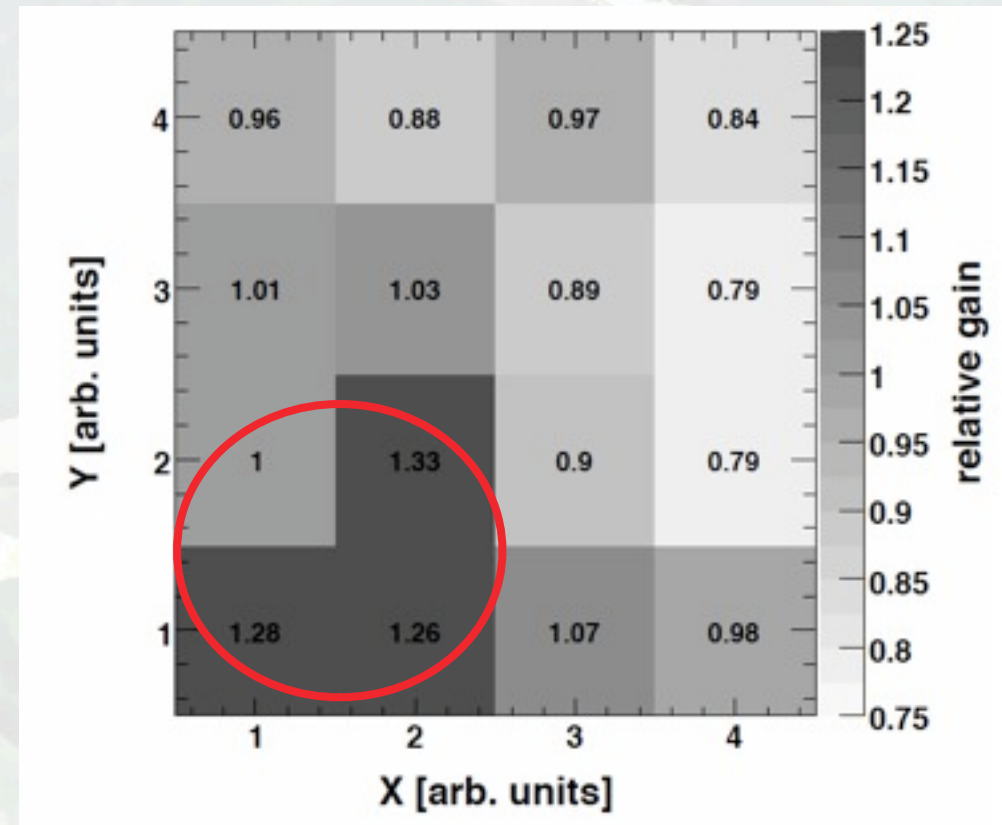
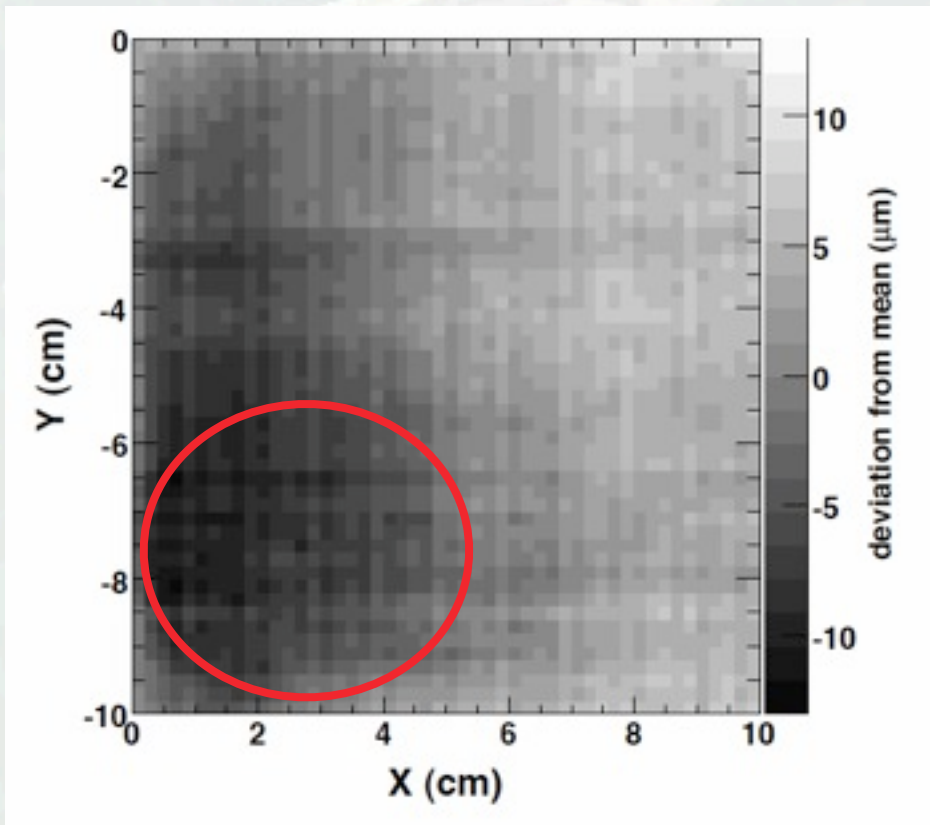


○ Comparison of optical scans of inner hole diameter uniformity and gain uniformity

from low-intensity  $^{55}\text{Fe}$  source ( $\sim 0.5\text{Hz}/\text{mm}^2$ ) measurements

# FGT Technical realization

## □ Source tests (5)



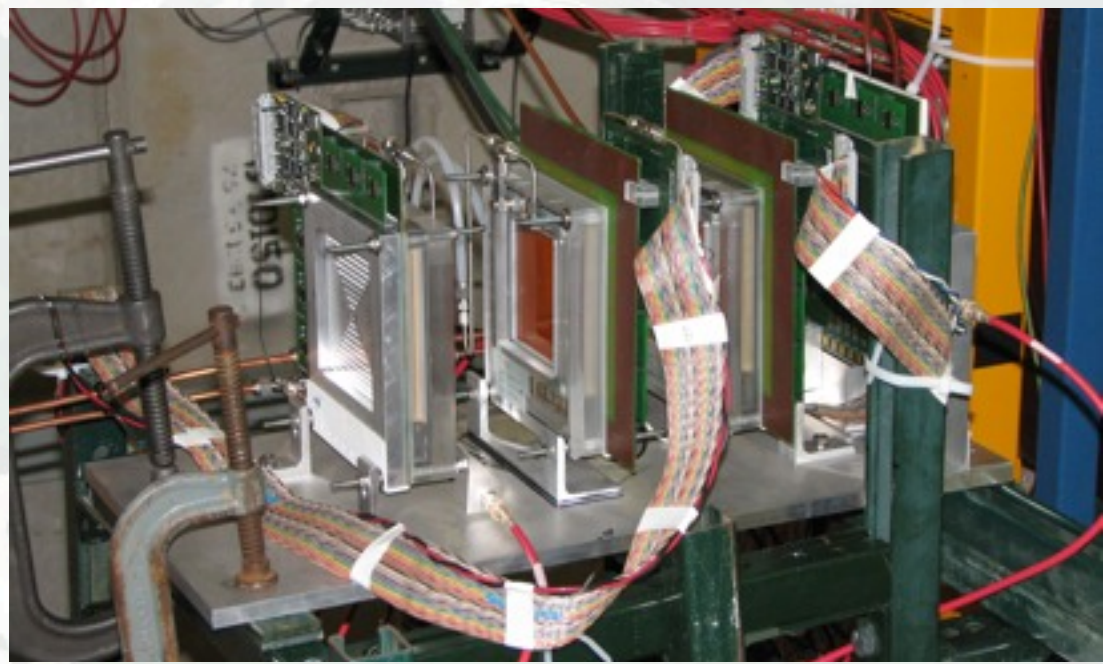
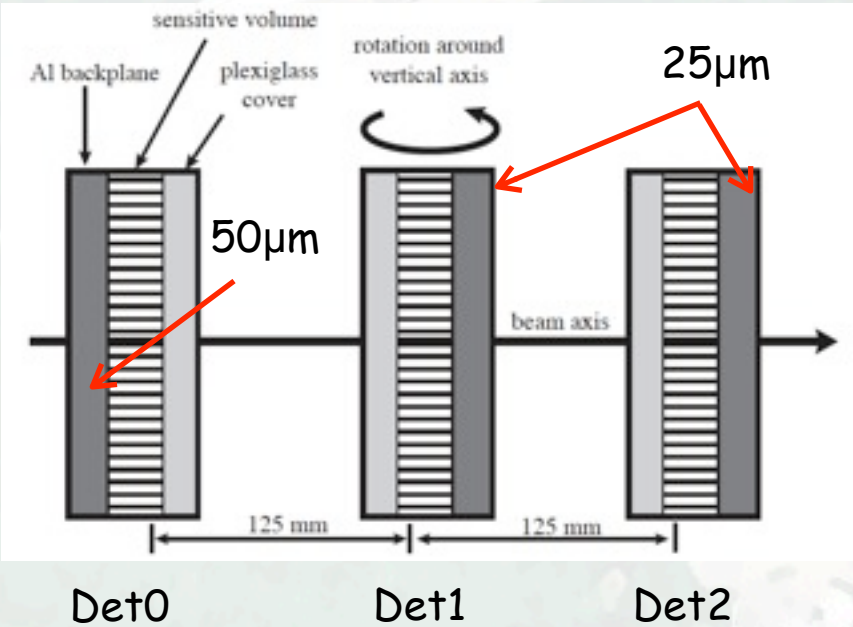
○ **Non-uniformity** of inner hole diameter ( $\sim 20\mu\text{m}$  smaller on left side compared to right side)

reflected in large non-uniformity of source scan gain measurements



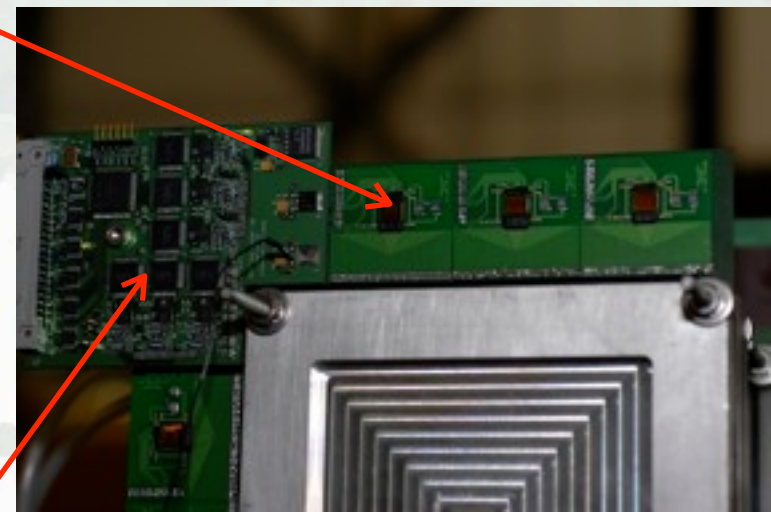
# FGT Technical realization

## Testbeam results (1)



APV25-S1

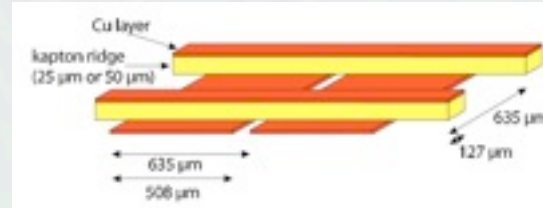
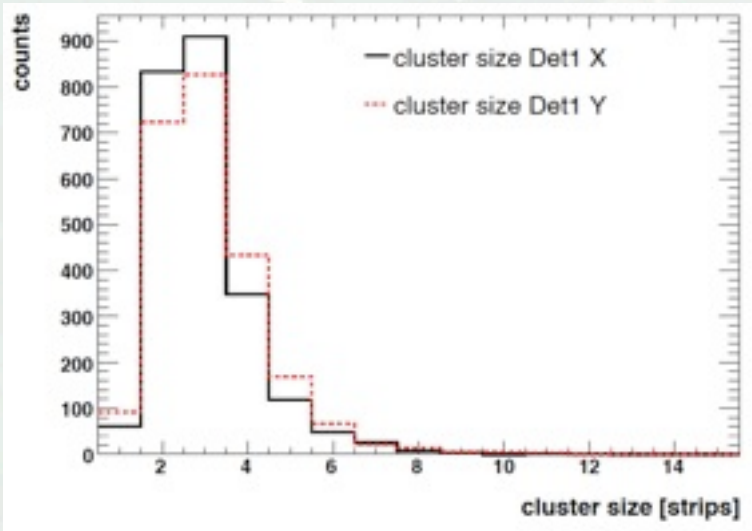
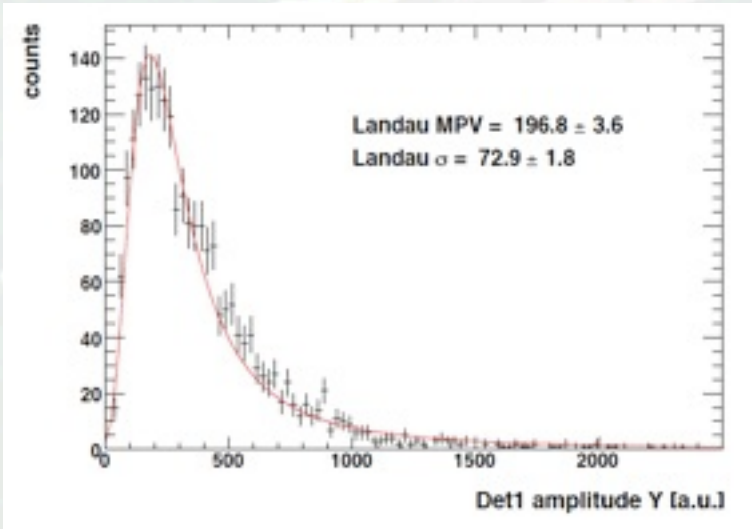
- FNAL Meson Test Beam Facility: Data taking with 4GeV-32GeV unseparated secondary beam and 120GeV primary proton beam



GEM Control Unit

# FGT Technical realization

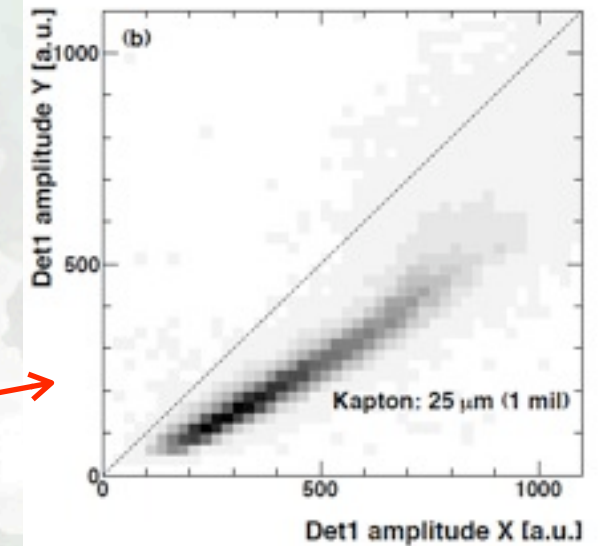
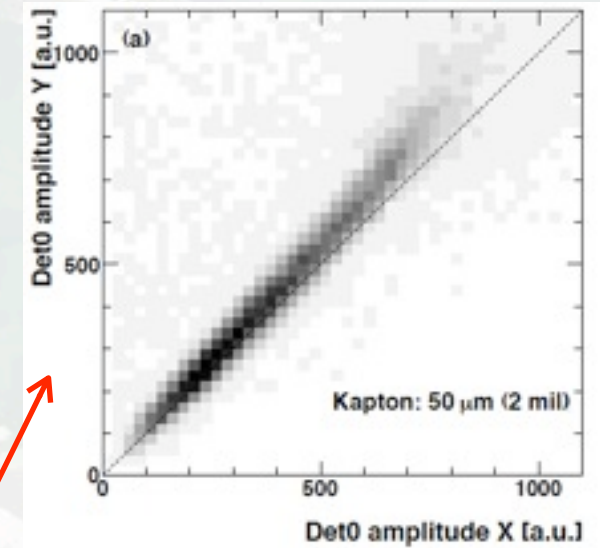
## □ Testbeam results (2)



- Cluster charge follows expected distribution

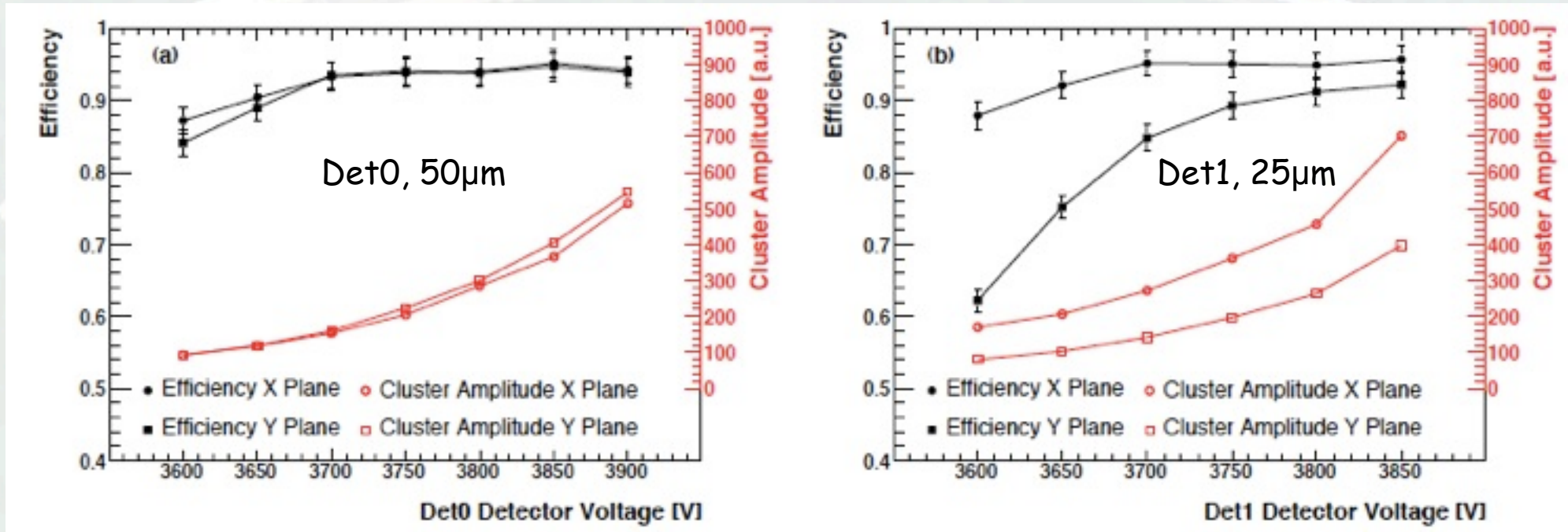
- Two version of readout board

(50 $\mu\text{m}$   
and 25 $\mu\text{m}$ )



# FGT Technical realization

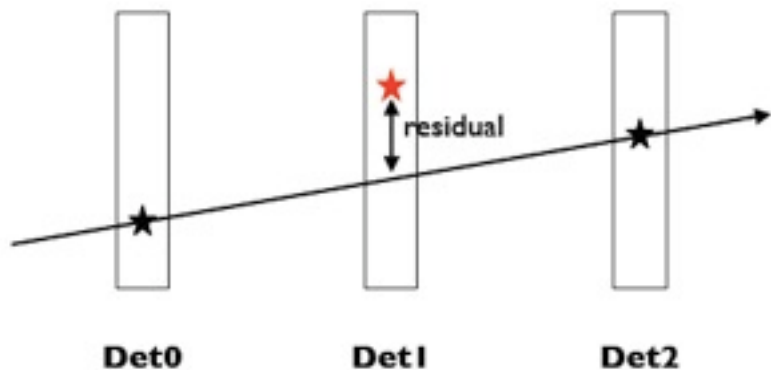
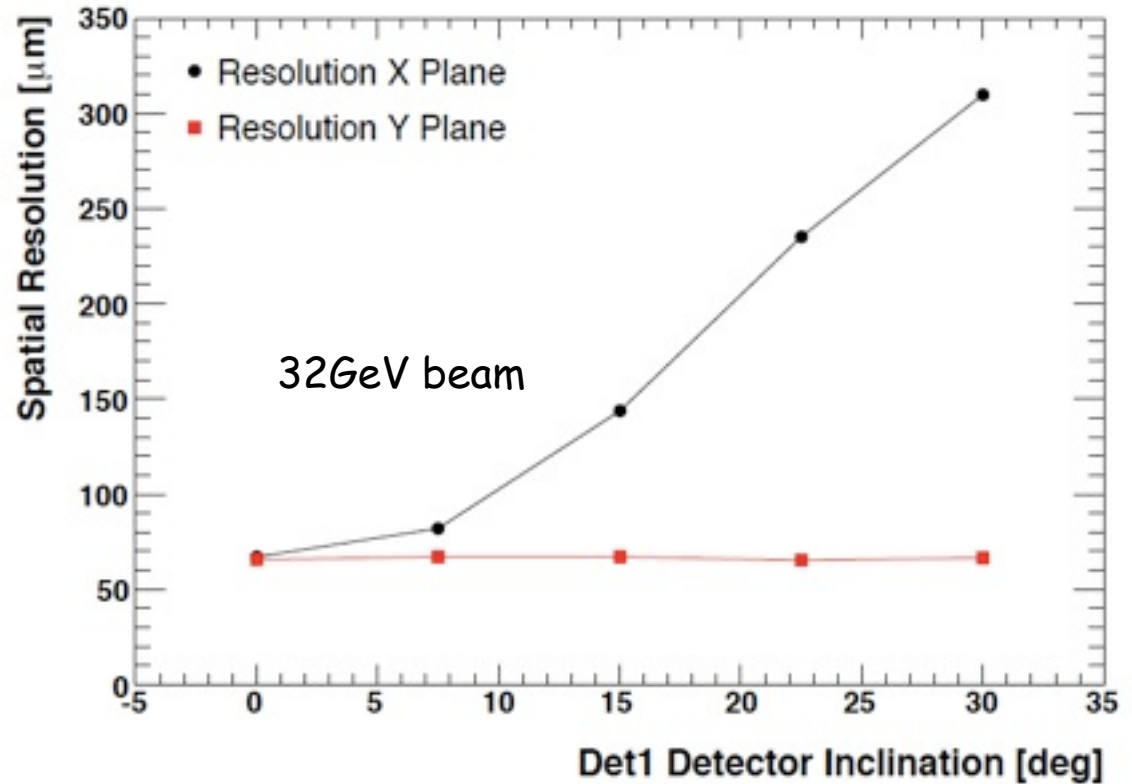
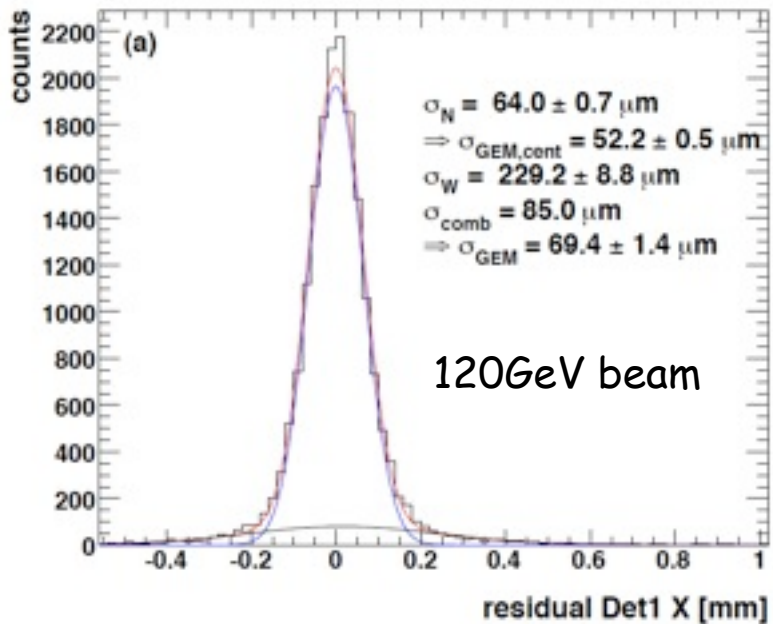
## □ Testbeam results (3)



- Efficiencies at the level of ~95%-98% were reached in regions which limit the impact of noisy and dead regions with Tech-Etch GEM foils (Not affected by high intensity studies)
- Clear difference between Det0 (50µm) and Det 1 (25µm) for efficiency and cluster amplitude (Most probable value of Landau distribution)

# FGT Technical realization

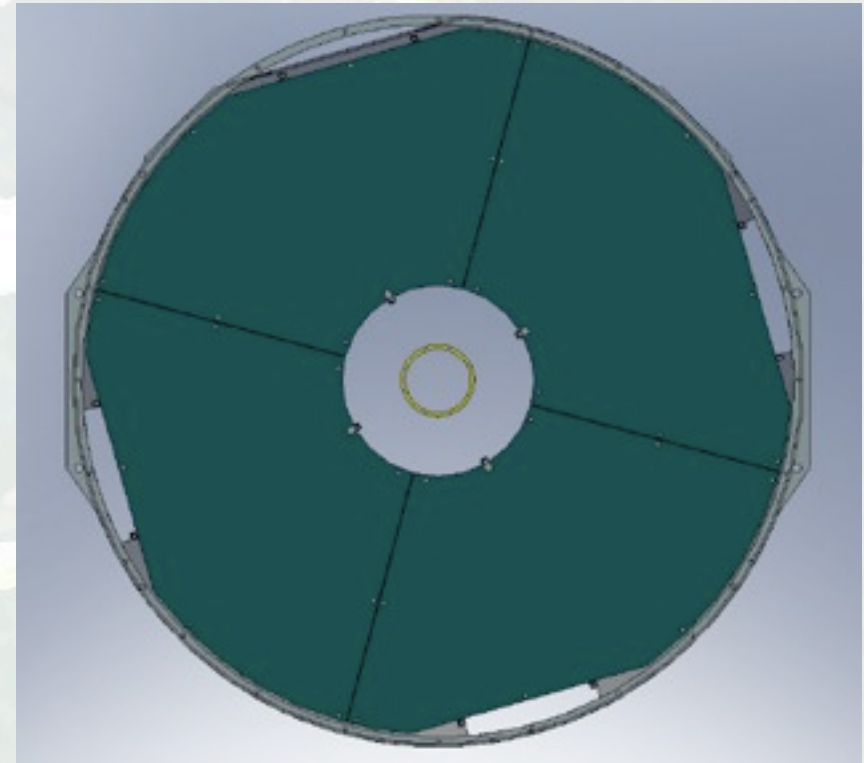
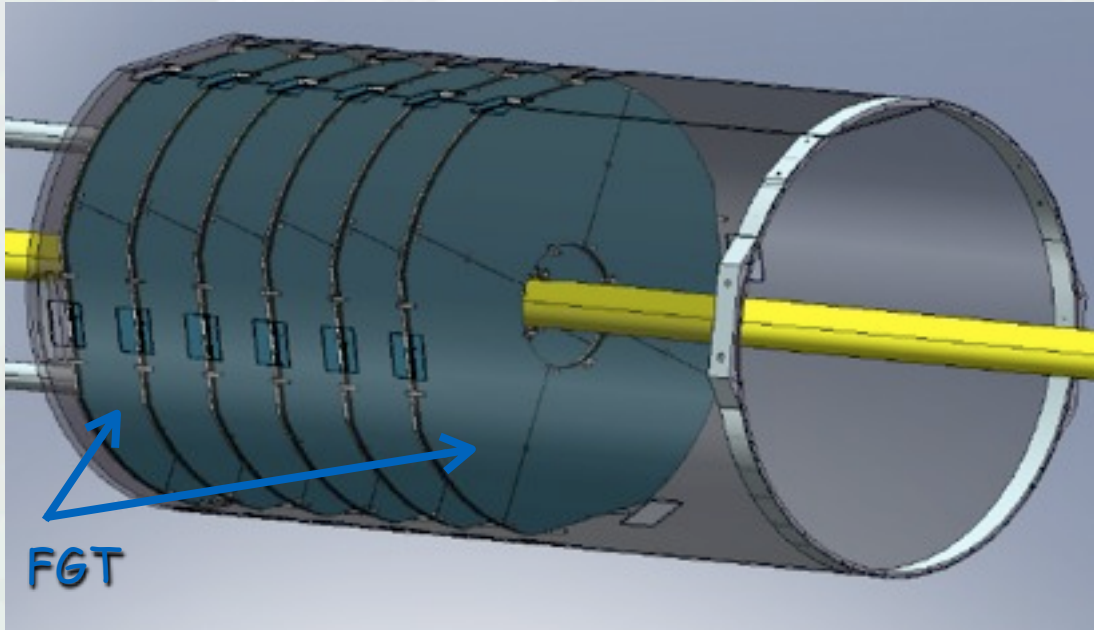
## □ Testbeam results (4)



- Study of inclination by up to  $30^\circ$ : Only X (horizontal) resolution is affected, not so for Y (vertical) coordinate as expected!

# FGT Technical realization

## □ Layout



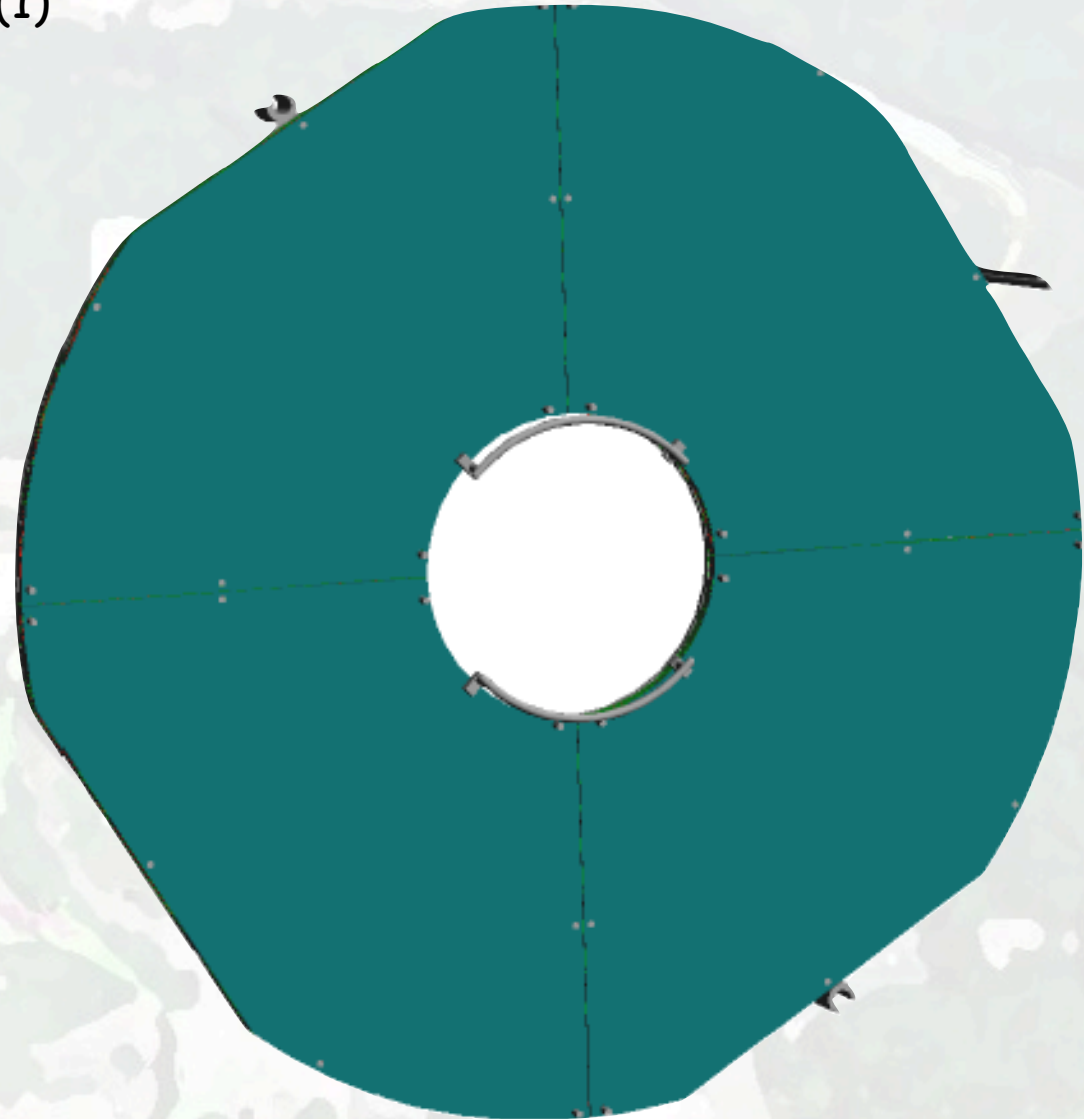
- FGT: 6 light-weight disks
- Each disk consists of 4 triple-GEM chambers (Quarter sections)
- Procurement and assembly of full quarter section prototype in preparation



# FGT Technical realization

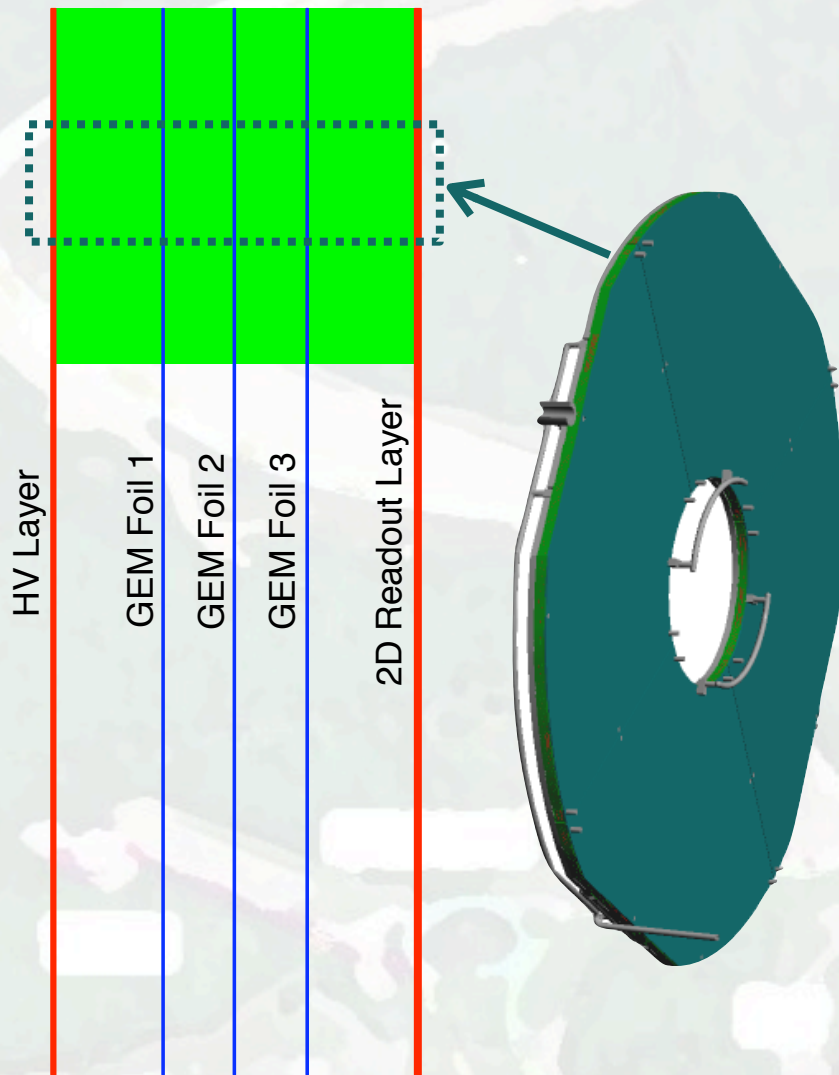
## □ Triple-GEM: Quarter section design (1)

- Single disk
  - 5mm Nomex honeycomb
  - 0.25mm FR4 skins
  - Pins used as part of assembly and alignment
- GEM quadrant
  - Pins define position
  - Pins preserve shape
- Gas manifolds and rails



# FGT Technical realization

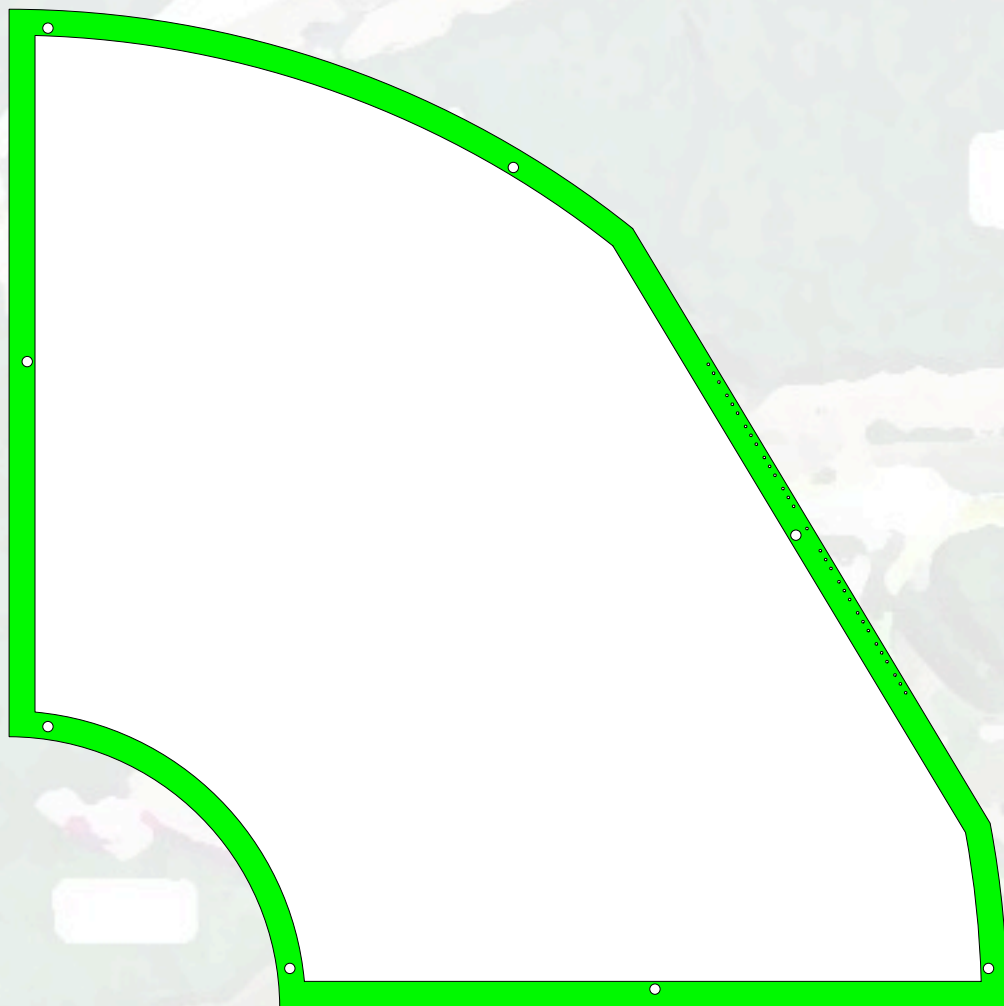
## □ Triple-GEM: Quarter section design (2)



| Component     | Material                        | Radiation Length [%] |
|---------------|---------------------------------|----------------------|
| Support plate | 5 mm Nomex                      | 0.040                |
|               | 2x250 $\mu\text{m}$ FR4         | 0.257                |
| HV layer      | 5 $\mu\text{m}$ Cu              | 0.035                |
|               | 50 $\mu\text{m}$ Kapton         | 0.017                |
| GEM foils     | 6x5 $\mu\text{m}$ Cu (70%)      | 0.147                |
|               | 3x50 $\mu\text{m}$ Kapton (70%) | 0.036                |
| Readout       | 5 $\mu\text{m}$ Cu (20%)        | 0.007                |
|               | 50 $\mu\text{m}$ Kapton (20%)   | 0.003                |
|               | 5 $\mu\text{m}$ Cu (88%)        | 0.031                |
|               | 50 $\mu\text{m}$ Kapton         | 0.017                |
|               | 5 $\mu\text{m}$ Cu (10%)        | 0.004                |
|               | 0.125 mm FR4                    | 0.064                |
|               | 5 $\mu\text{m}$ Cu (10%)        | 0.004                |
| Drift gas     | 10 mm CO <sub>2</sub> (30%)     | 0.002                |
|               | 10 mm Ar (70%)                  | 0.006                |
| <b>Total</b>  |                                 | <b>0.670</b>         |

# FGT Technical realization

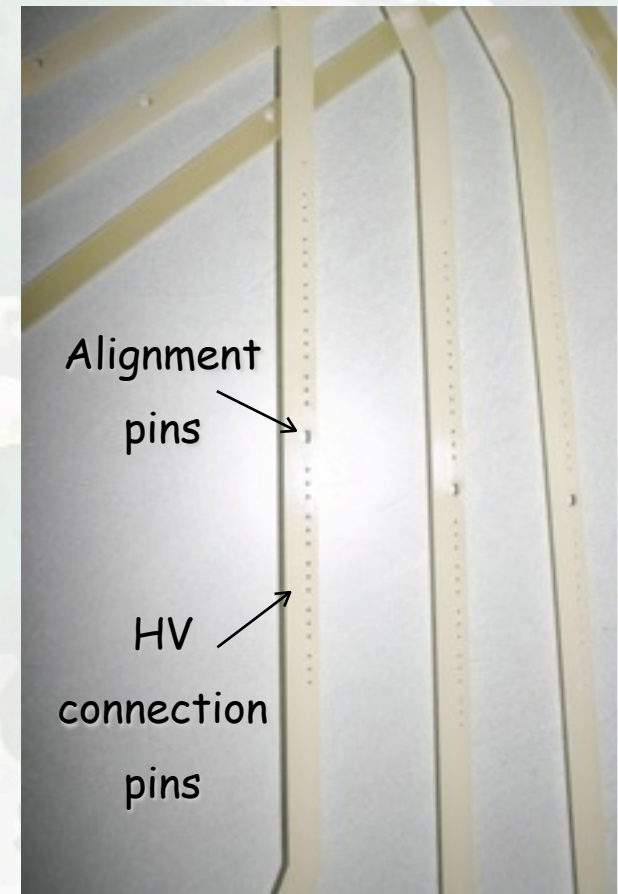
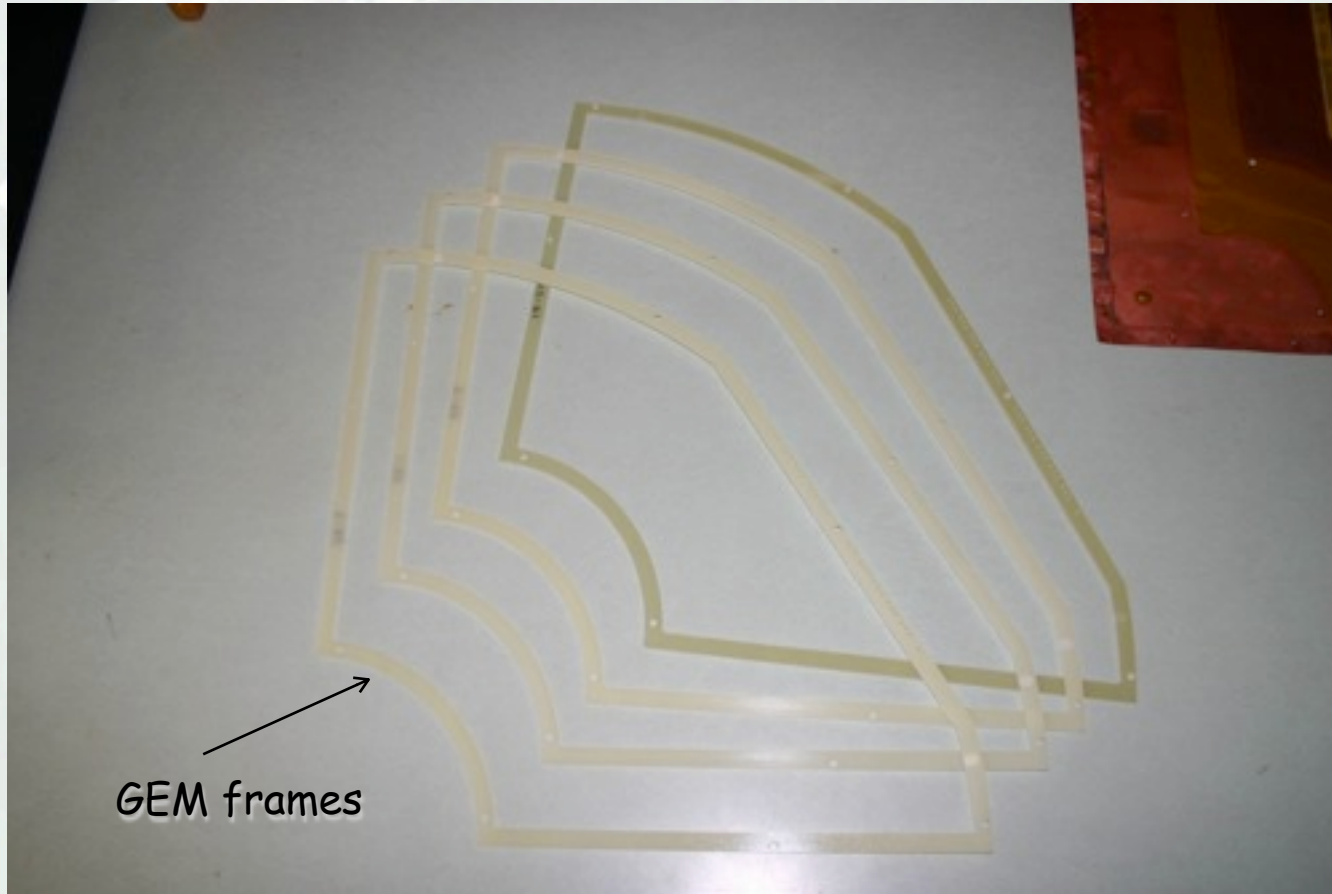
## □ Triple-GEM: Quarter section design (3)



- 1cm wide frames of FR4
- 2-3mm thick
- Inner radius: 10.5cm
- Outer radius: 38.1cm
- Flat at 31°
- 1mm gap between quadrants
- 4mm FR4 pins
- 34 X 1mm holes for HV GEM foil connection

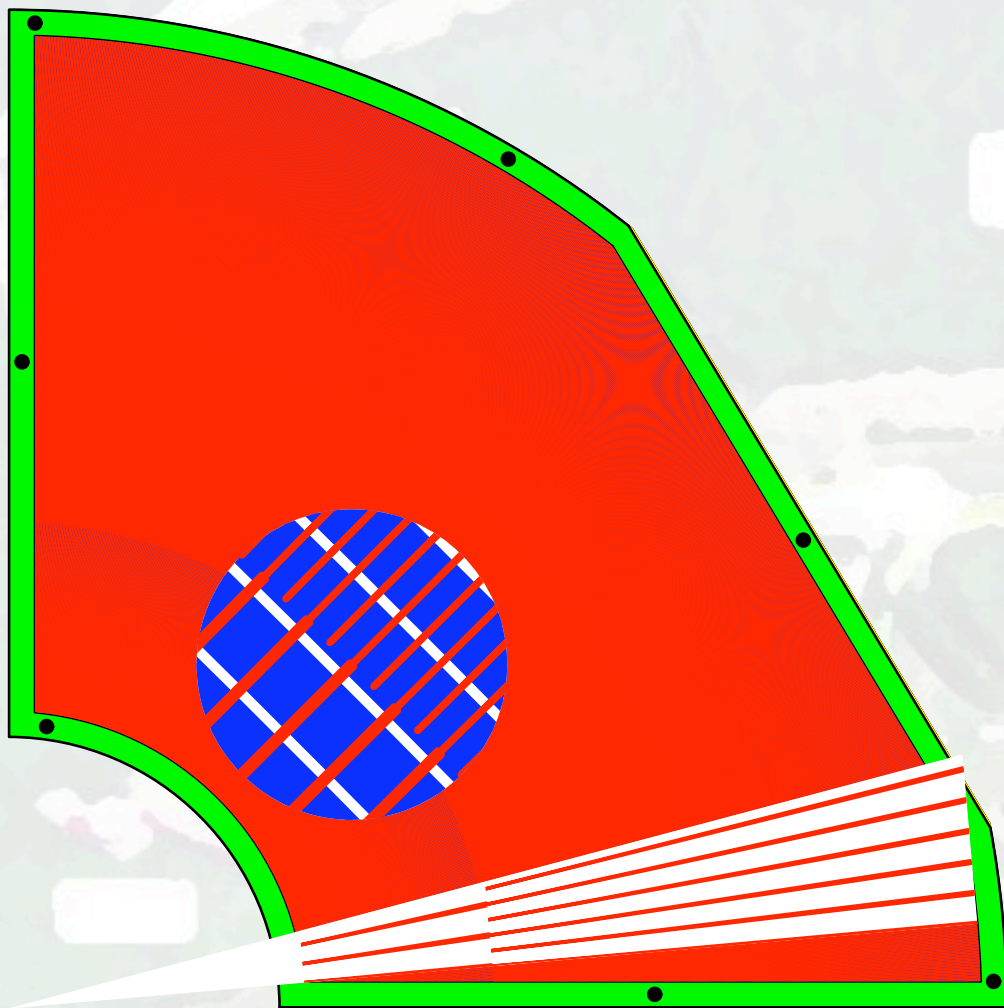
# FGT Technical realization

- Triple-GEM: Quarter section design (4)



# FGT Technical realization

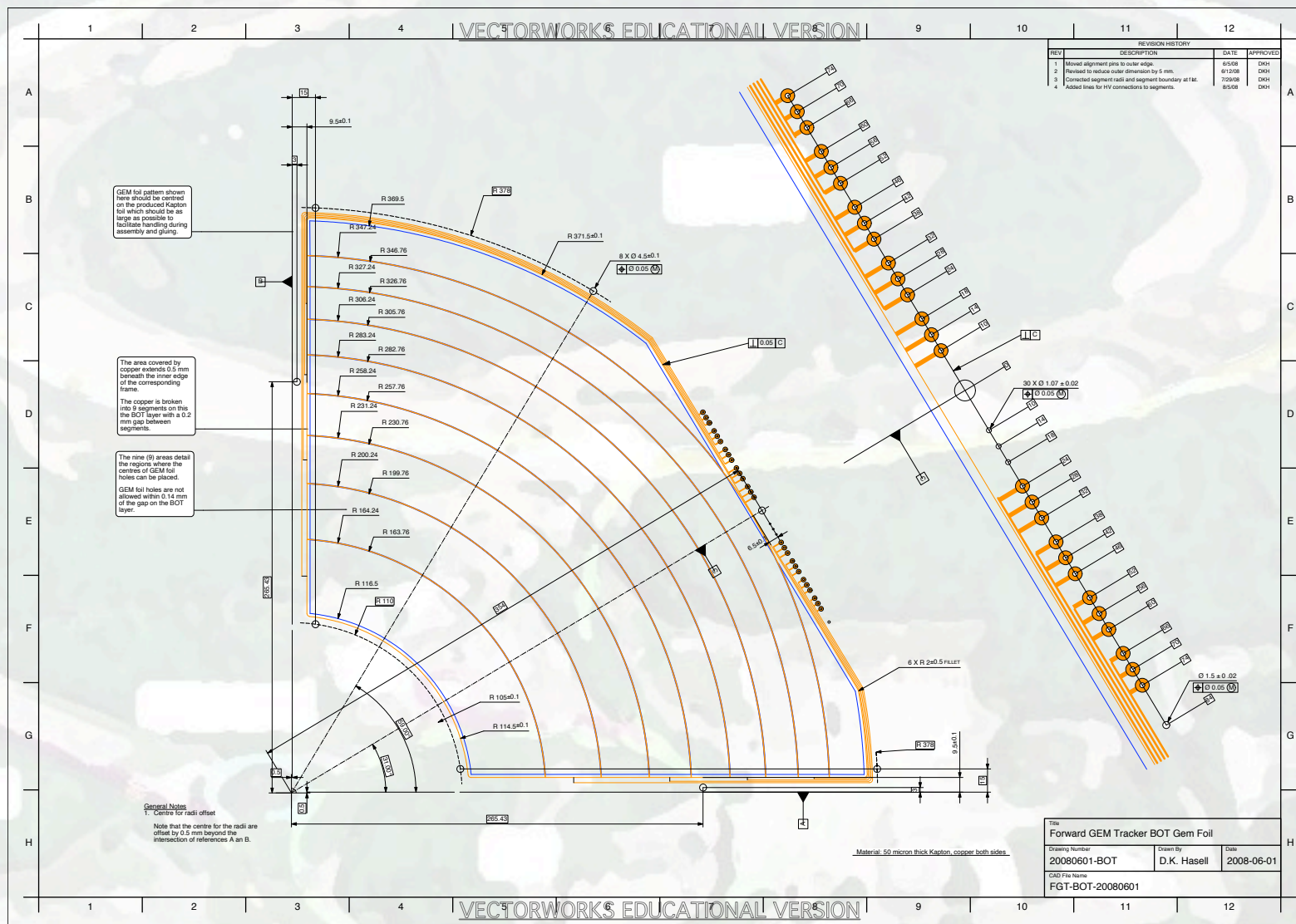
## □ Triple-GEM: Quarter section design (5)



- 50  $\mu\text{m}$  Kapton
- Copper on both sides
- Laser etching exposes bottom layer
- Top layer
  - $\Phi$ -readout layer
  - Alternate lines end at 18.8cm
  - Pitch: 300-600  $\mu\text{m}$
  - Line width: 80-120 $\mu\text{m}$
- Bottom layer
  - R-readout layer
  - Pitch: 800 $\mu\text{m}$
  - Line width: 700 $\mu\text{m}$

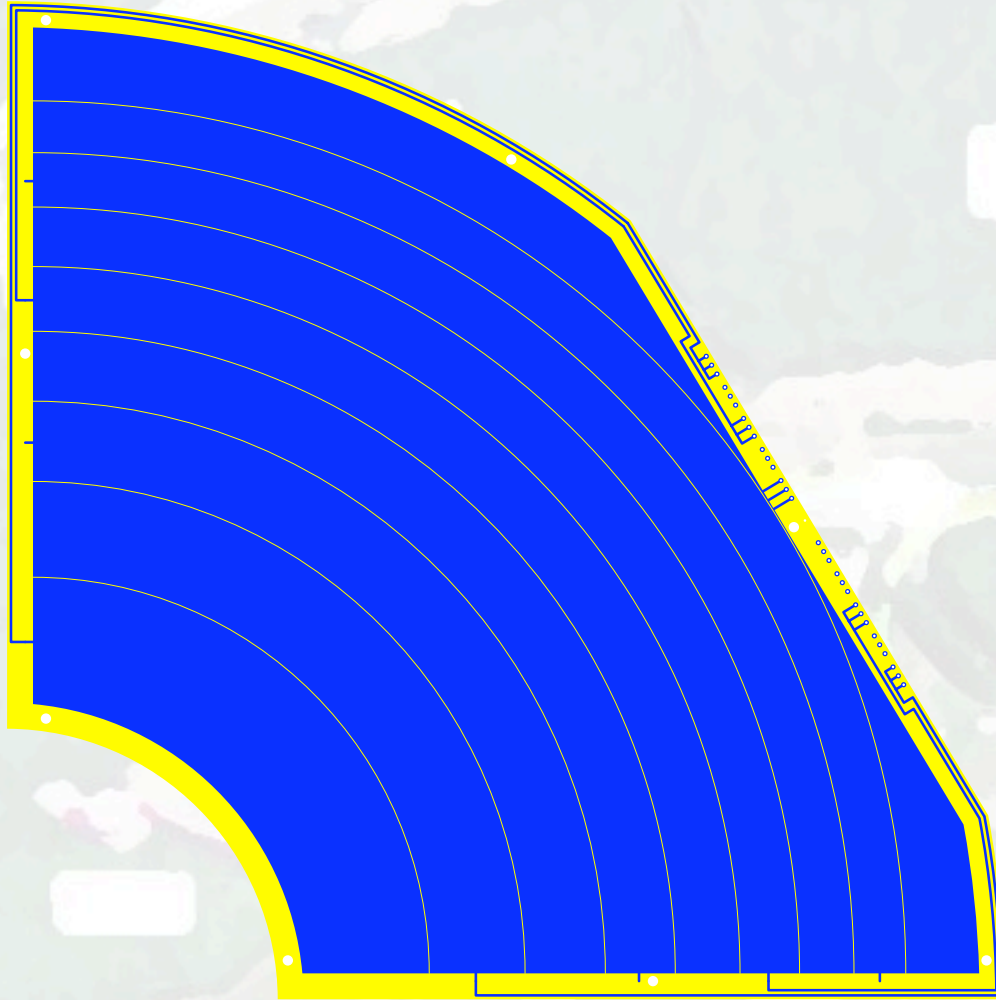
# FGT Technical realization

## Triple-GEM: GEM foil design (1)



# FGT Technical realization

## □ Triple-GEM: GEM foil design (2)



### Segmented GEM foils:

- Minimize damage in case of breakdown
- 9 segments in radial direction with  $\sim 100\text{cm}^2$  each
- Gap:  $200\mu\text{m}$
- Hole pitch ( $\sim 140\mu\text{m}$ ) and diameter (I:  $\sim 50\mu\text{m}$  / O:  $\sim 60\mu\text{m}$ ) similar to prototype!
- Routing and vias distribute HV to segments



# FGT Technical realization

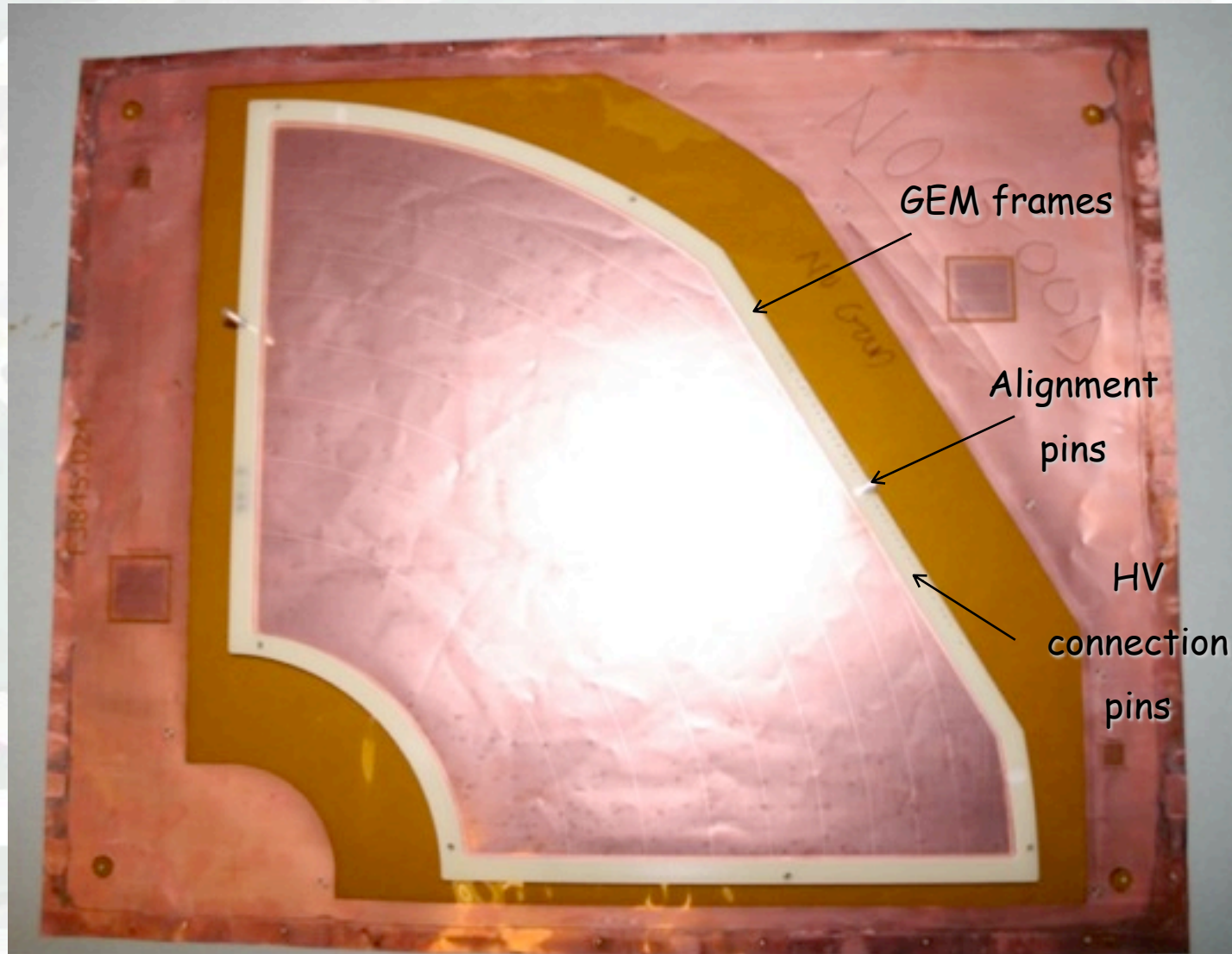
- Triple-GEM: GEM foils at MIT (1)





# FGT Technical realization

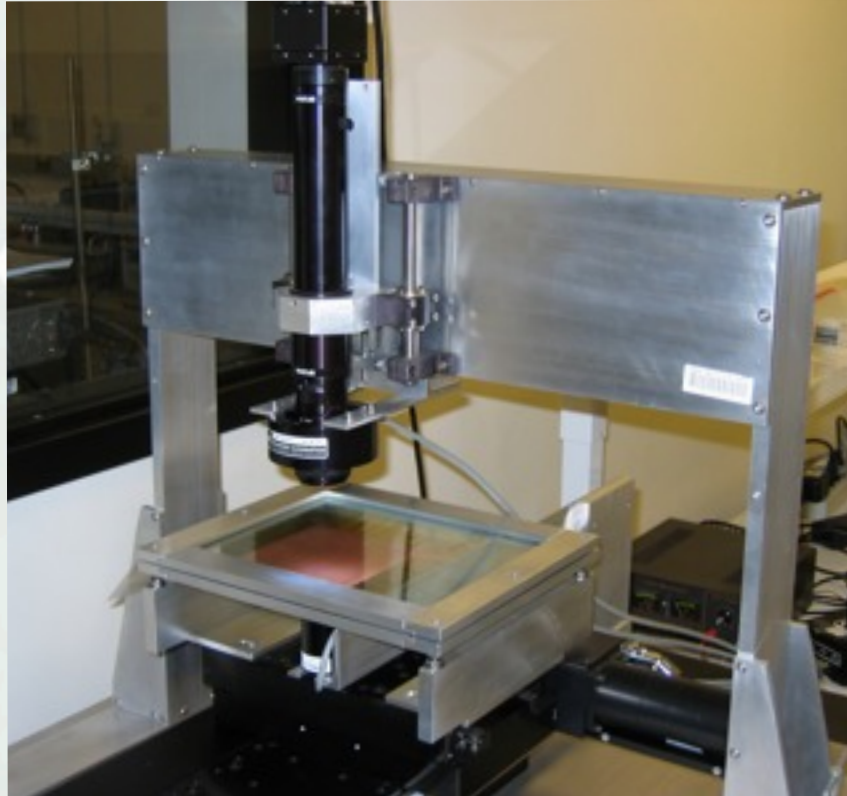
- Triple-GEM: GEM foils at MIT (2)





# FGT Technical realization

## □ Triple-GEM: GEM foil testing (1)



CCD camera setup for optical GEM foil scans

(Glass plate modifications in progress)

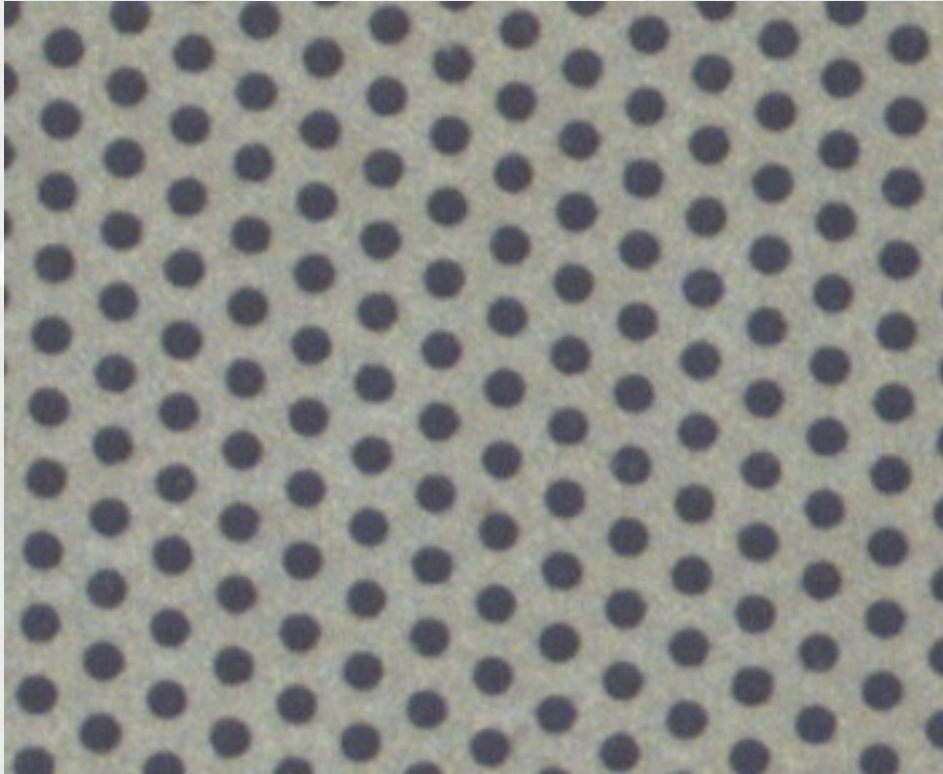


HV Vacuum / Nitrogen box for GEM foil dark current tests

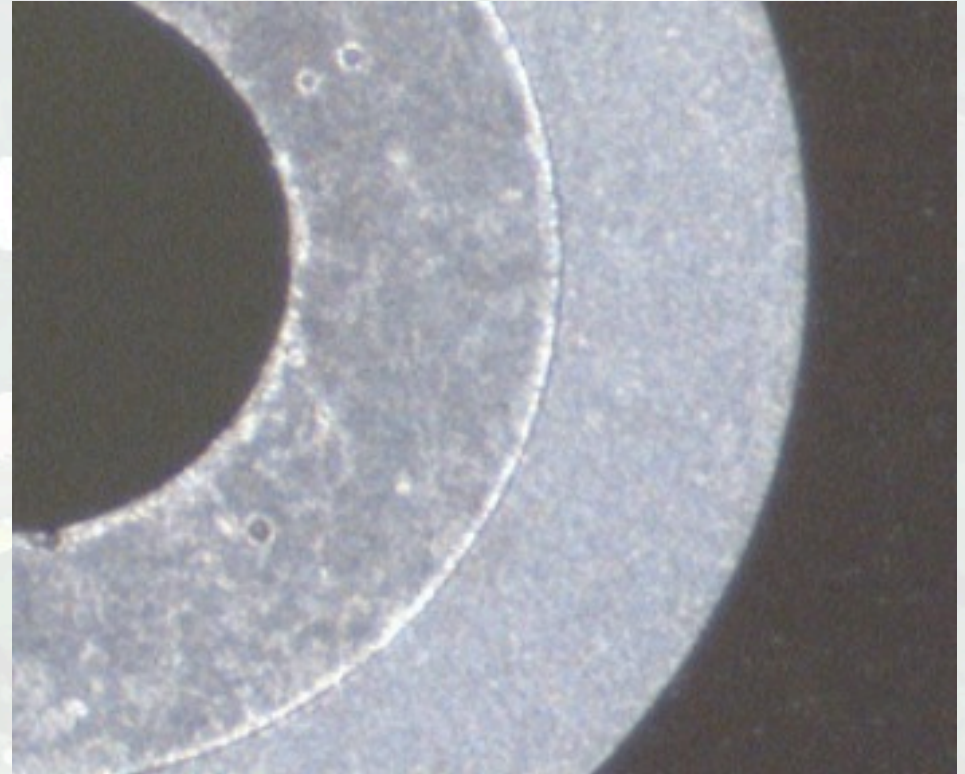
(Minor modifications necessary - In progress)

# FGT Technical realization

- Triple-GEM: GEM foil testing (2)



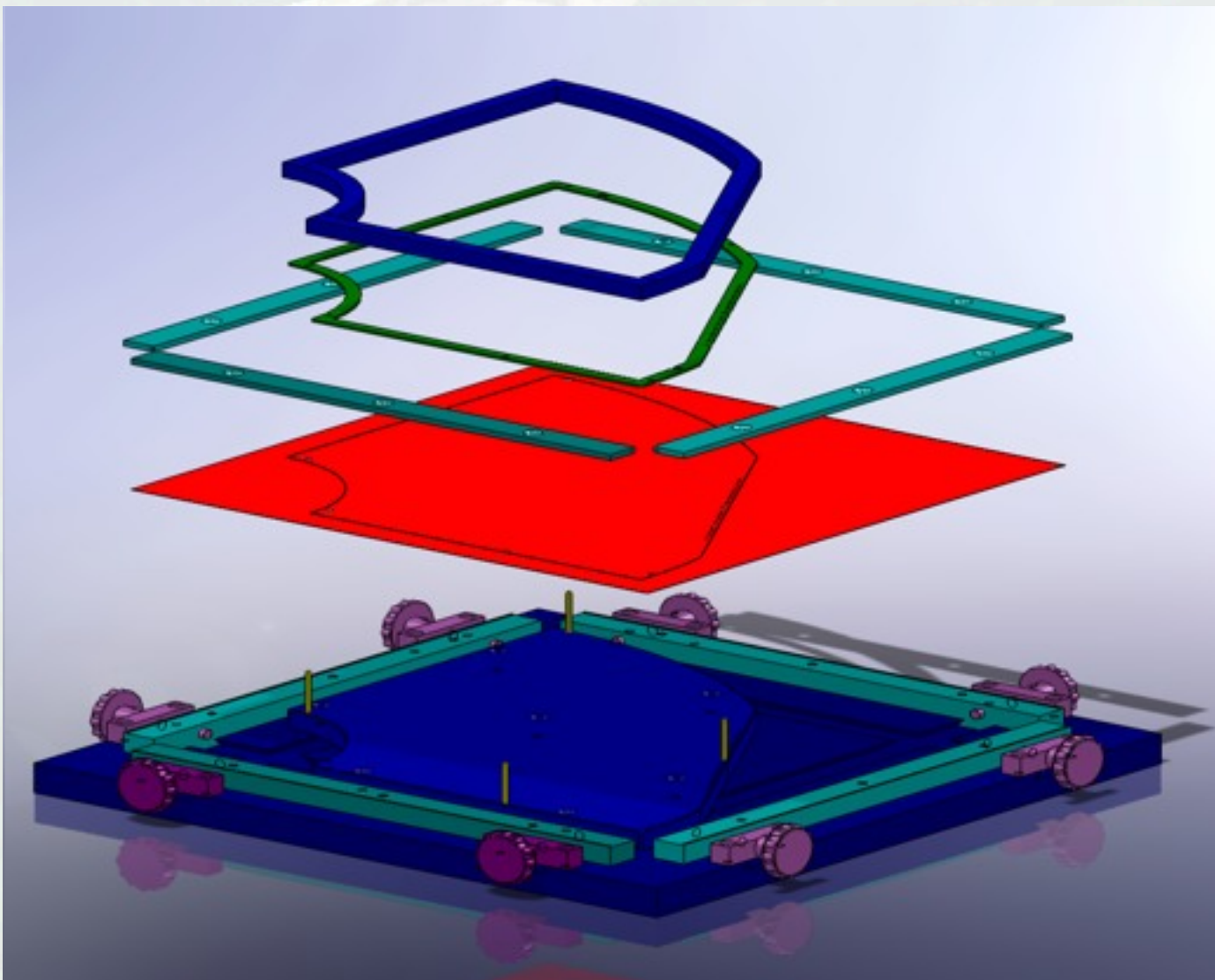
First scan for large GEM foil  
(Hole arrangement)



First scan for large GEM foil  
(HV connection)

# FGT Technical realization

- Triple-GEM: GEM foil stretching and assembly tooling



## Stretching jig:

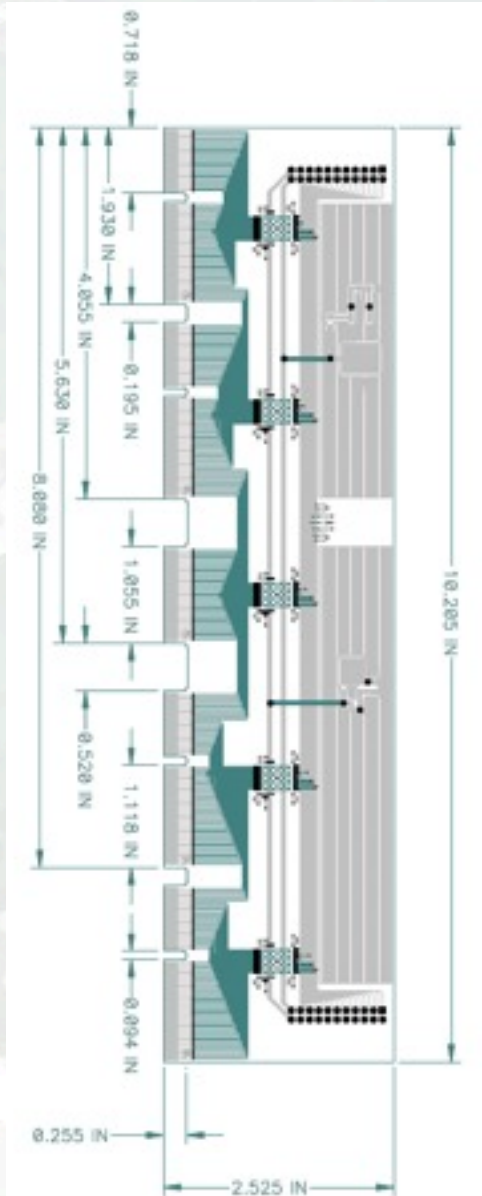
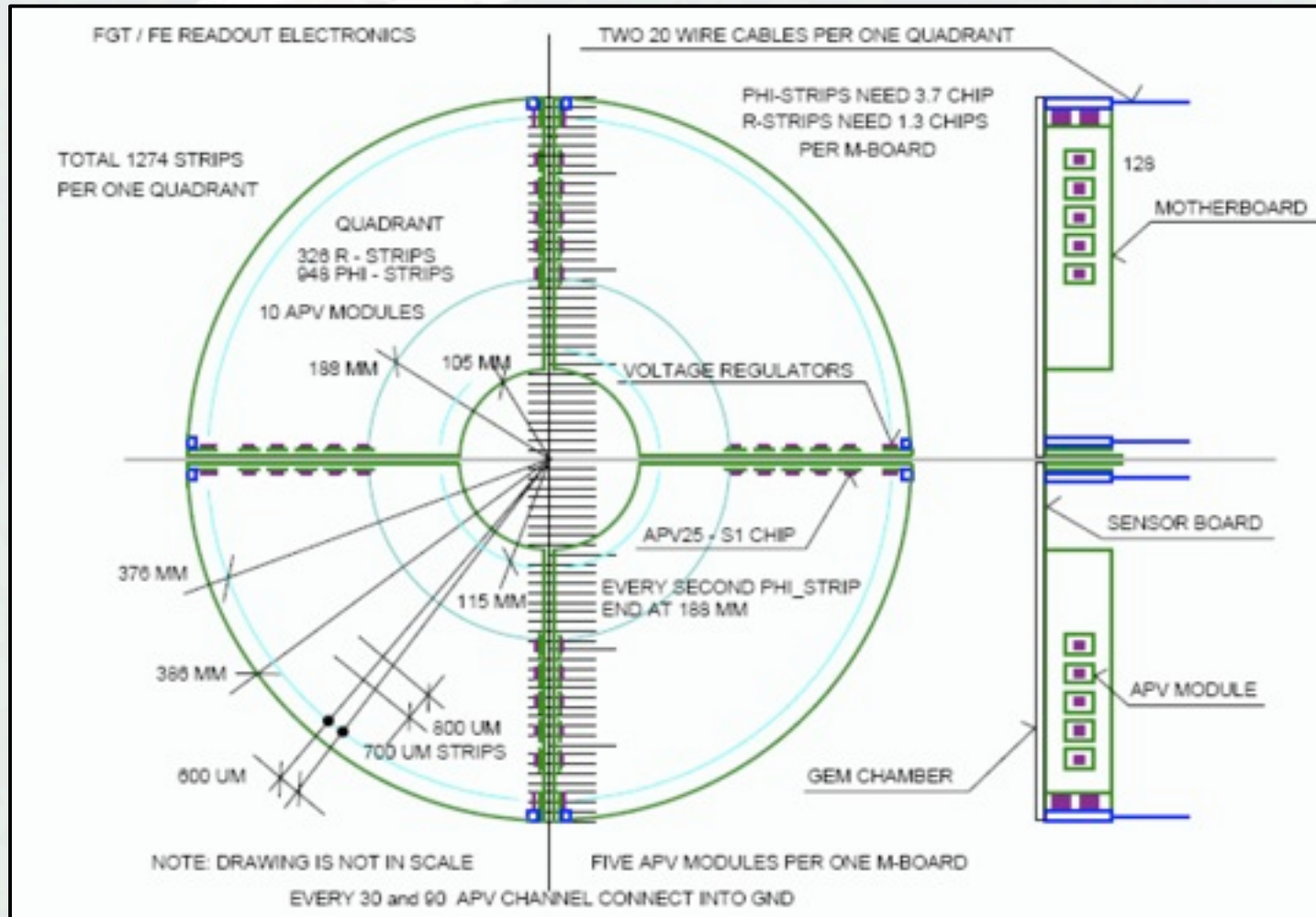
- Stretch GEM foil
- Clamp 2mm spacer for single glue operation

## Assembly jig:

- Align frames to each other and to SIMM pins
- Hold frames flat with clamps
- Hold SIMM pins in place for soldering
- Clamp frames together for gluing operation

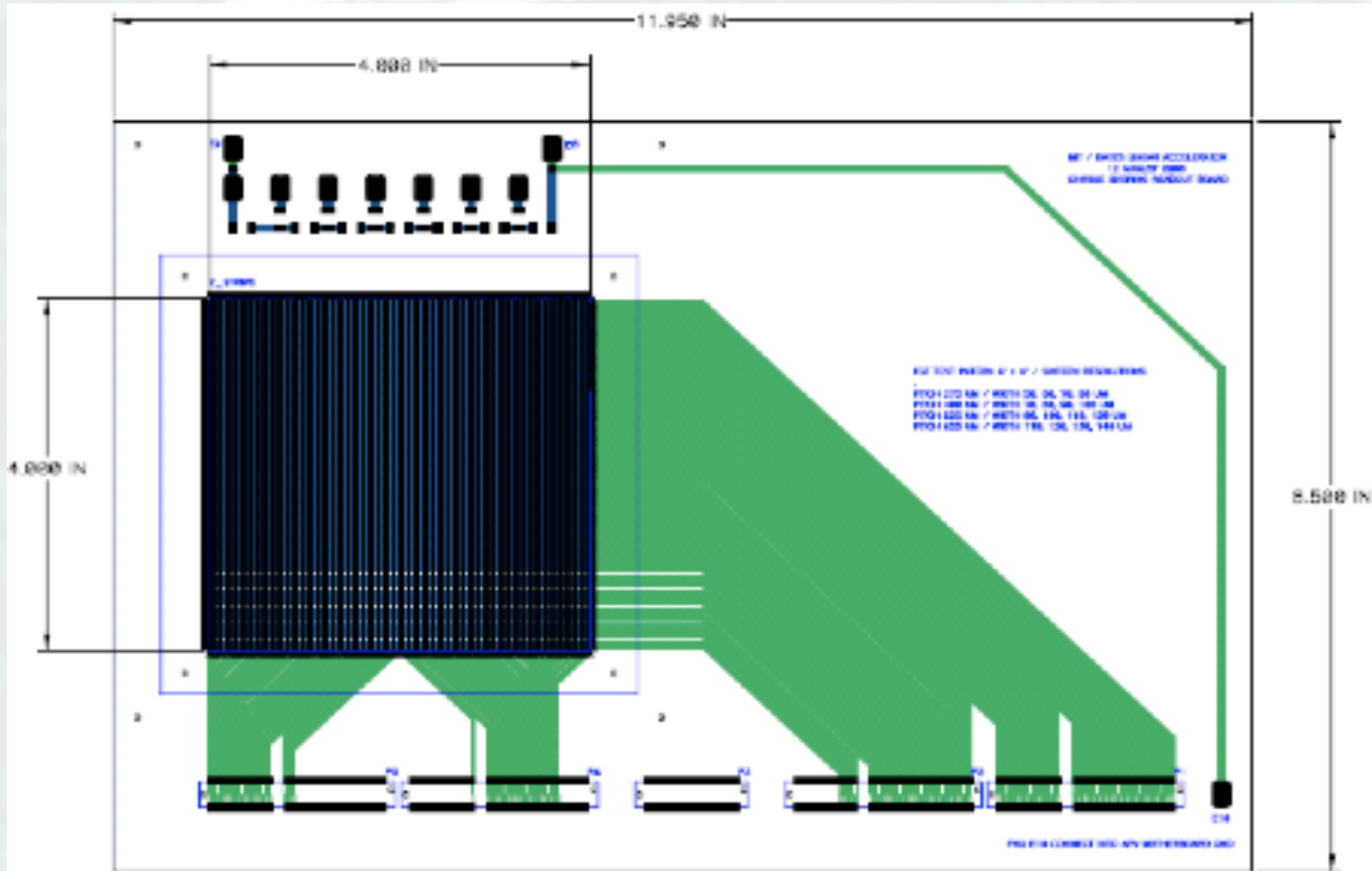
# FGT Technical realization

## Triple-GEM: 2D readout board design (1)



# FGT Technical realization

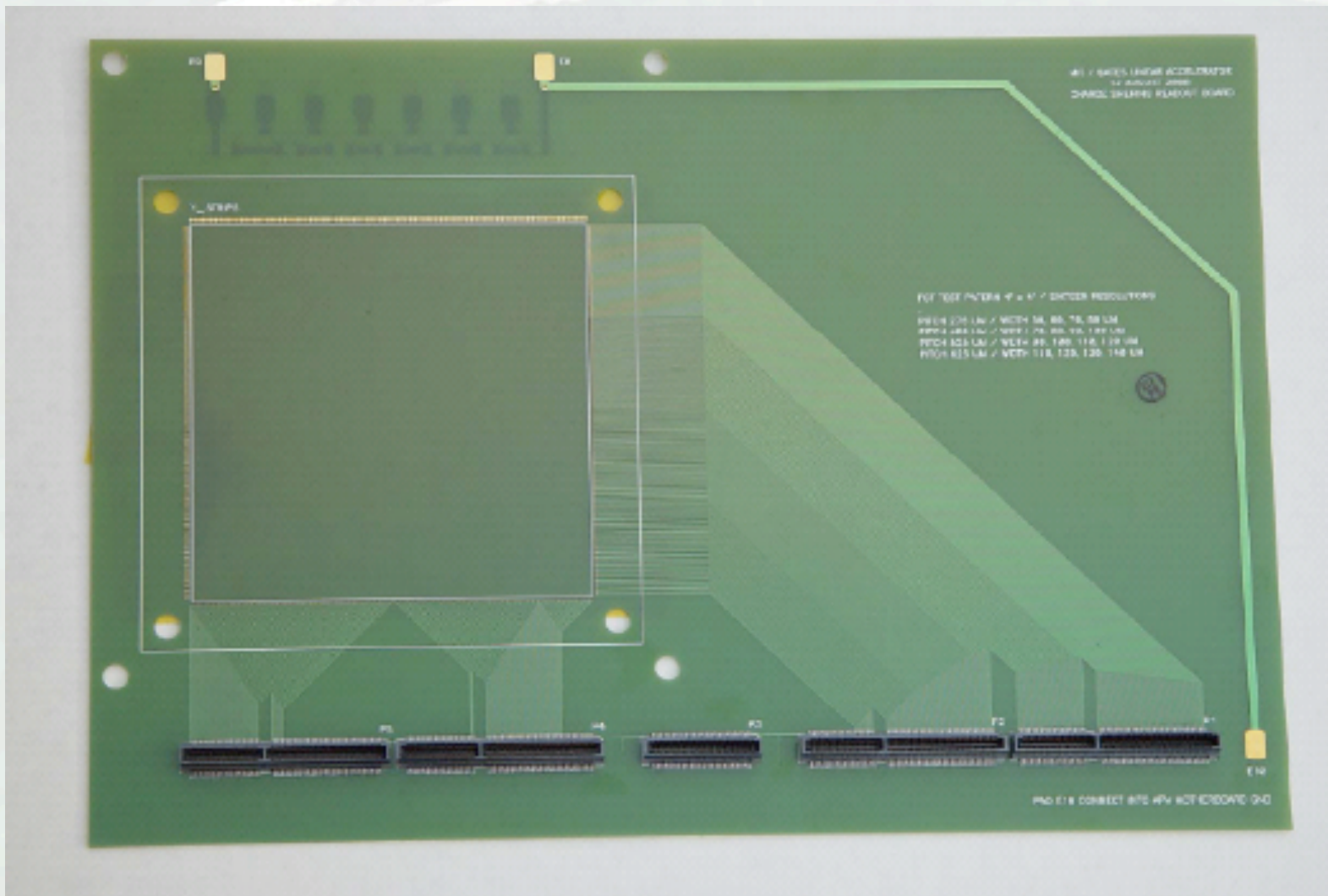
## Triple-GEM: 2D readout board design (2)



- Special 2D readout board designed (Suitable for  $10 \times 10 \text{ cm}^2$  prototype arrangement)
- 4 X 4 separate regions of different strip pitch/width

# FGT Technical realization

## □ Triple-GEM: 2D readout board design (3)



- Manufactured by Compunetics Inc.
- Delivered to MIT-Bates, December 2009
- Assembly in progress



# FGT Technical realization

- Triple-GEM: Plans / Issues (Until June 2009)
  - Finish tests of large GEM foils
  - Charge sharing board assembly and test
  - Finalize design of 2D readout board and order full scale 2D readout board prototype
  - Assembly and test of full scale prototype (Source test and cosmic ray test setup)
  - Order of GEM foils and beginning of testing

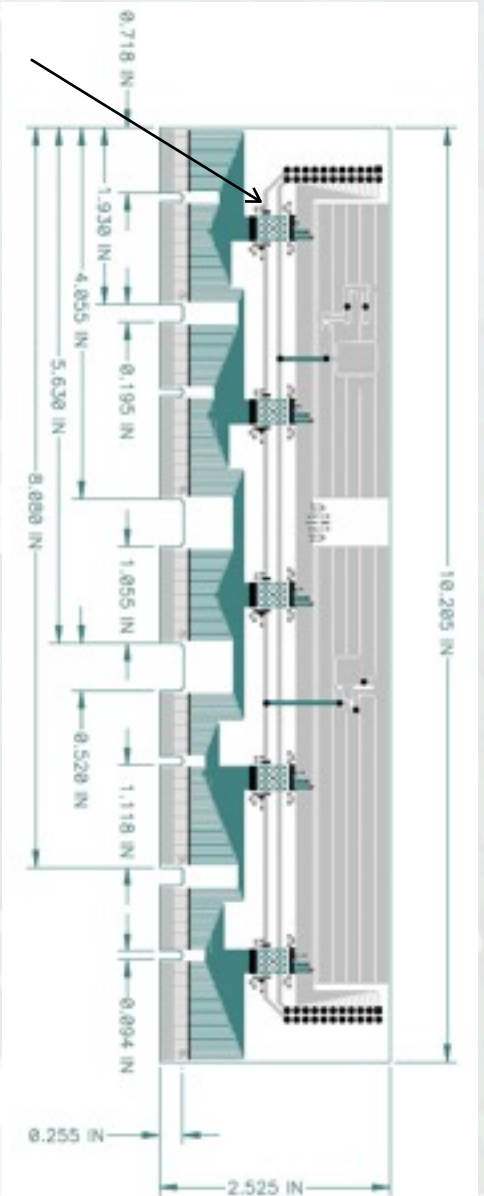
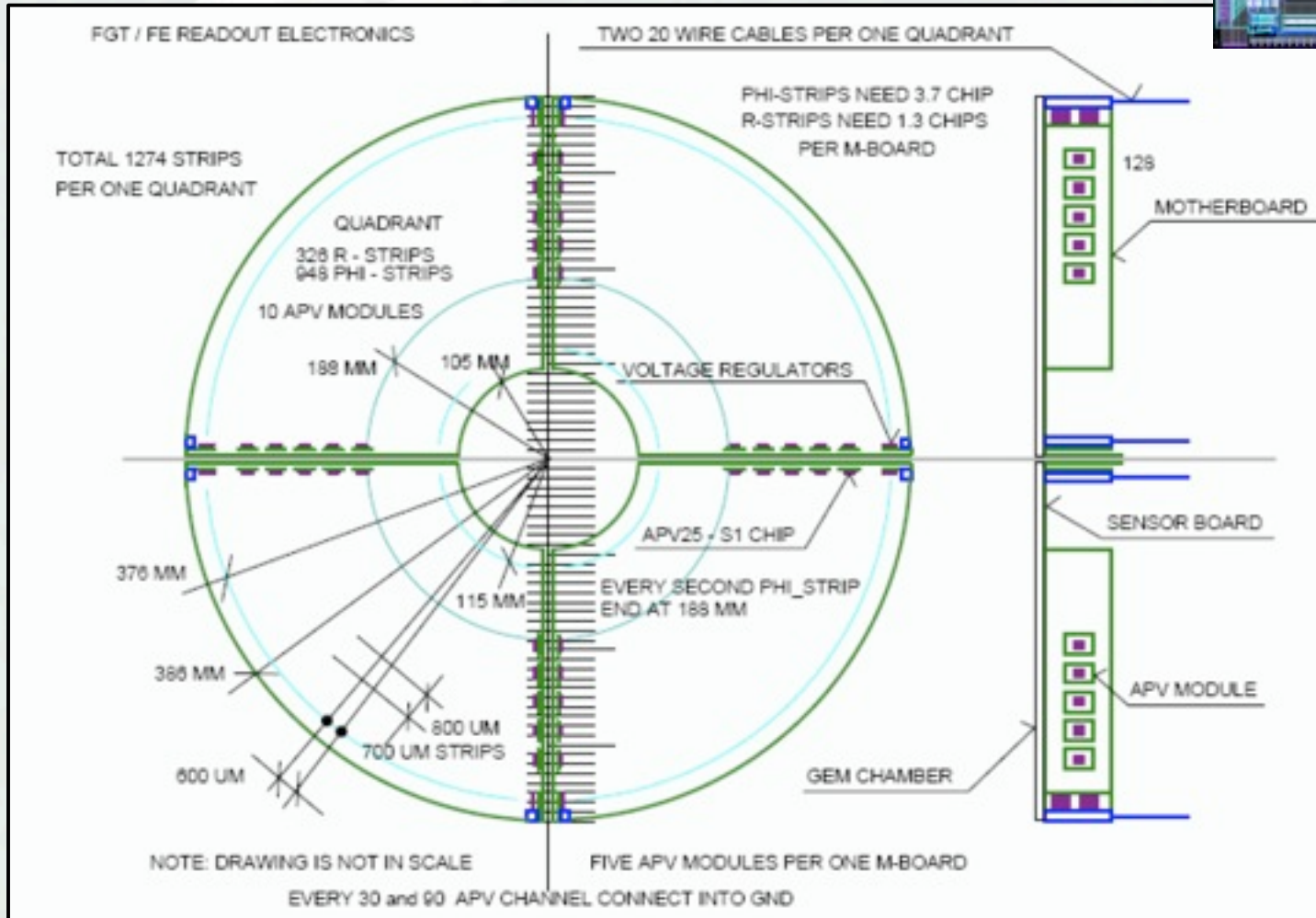
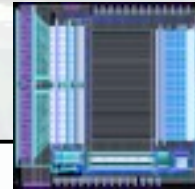




# FGT Technical realization

## □ FEE: Overview

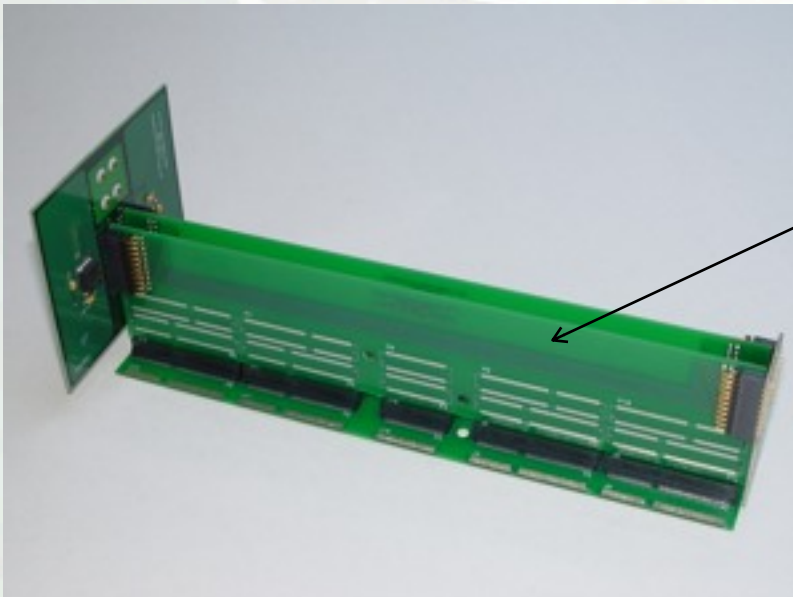
APV25-S1 chips



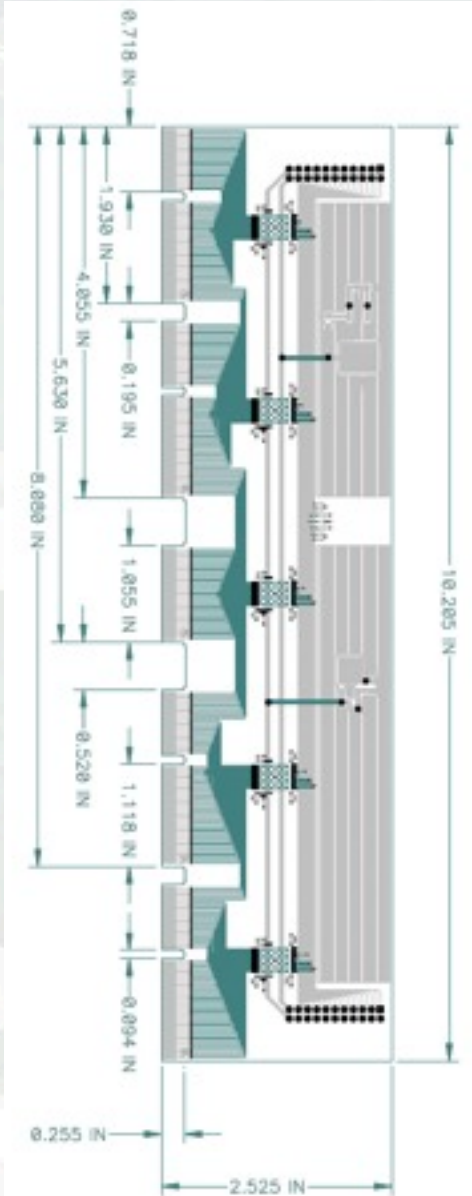
# FGT Technical realization

## □ FEE: APV module

- Design of APV module completed
- Fabrication of APV module ongoing by Compunetics Inc.
- APV module will be used for test-charge board and full-scale prototype



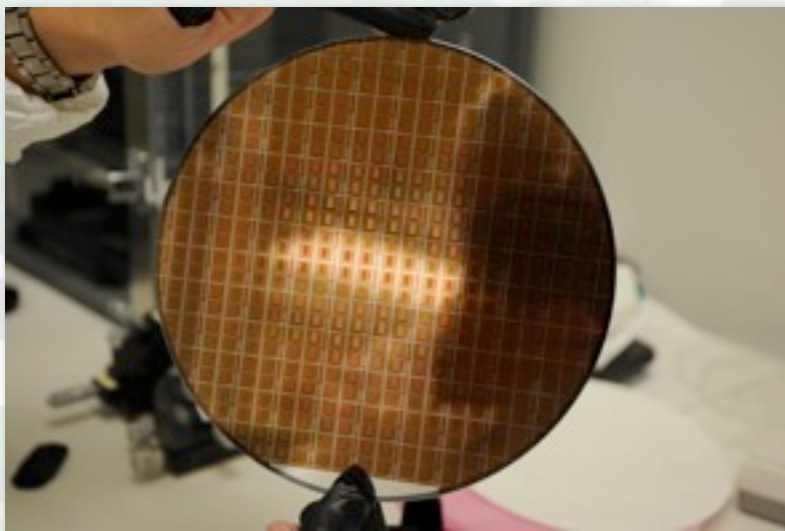
APV test module for  
multi-pin connector tests





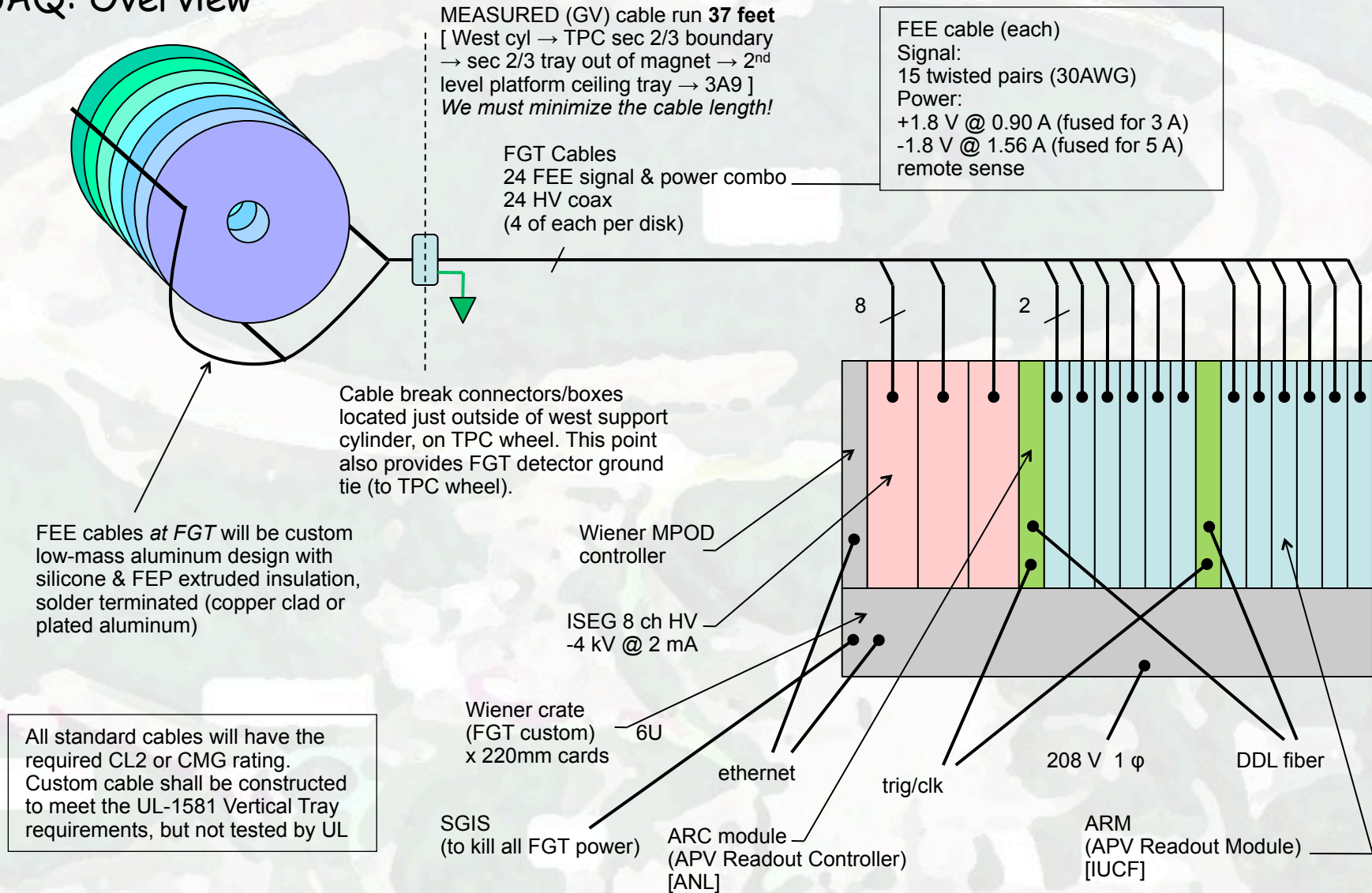
# FGT Technical realization

- FEE: APV25-S1 chips at MIT



# FGT Technical realization

## □ DAQ: Overview



# FGT Schedule / Milestones

## □ Overview - Planing

- **Goal:** Installation in summer 2010  $\Rightarrow$  Ready for anticipated first long 500GeV polarized pp run in FY11 consistent with STAR 5-year Beam Use Request
- **Review:** Successful review January 2008 / Beginning of construction funds FY08
- **Cost estimate and planing** relies on the R&D and pre-design work:
  - **Triple-GEM Detector:** Complete prototype tested on the bench and during FNAL testbeam experiment with extensive experience in mechanical design work (MIT-Bates) and assembly including previous experience at COMPASS
  - **Front-End Electronics (FEE) System:** Complete prototype tested on the bench and during FNAL testbeam experiment based on existing APV25-S1 readout chip (MIT-Bates)
  - **Data Acquisition (DAQ) System:** Conceptual layout is based on similar DAQ sub-detector systems with extensive experience (ANL/IUCF)
  - **GEM foil development:** Successful development of industrially produced GEM foils through SBIR proposal in collaboration with Tech-Etch Inc. (BNL, MIT, Yale University)



# Summary and Outlook

## □ Summary

- Exciting program of **W production** in polarized proton-proton collisions at RHIC **constraining unknown u/d anti-quark distributions**
  - Clear sensitivity in particular at forward rapidity
- STAR experiment requires **upgrade of forward tracking system** for **charge sign discrimination of electrons/positrons**
- **Triple-GEM technology** provides a cost effective way for a forward tracking upgrade solution
- **Successful development of industrial production of GEM foils** (SBIR proposal with Tech-Etch Inc.) - Test of large GEM foils ongoing
- **Successful beam test at FNAL** demonstrates that performance meets requirements
- Design work being finalized - **Pre-production underway**
- **Goal:** Installation summer 2010 to be ready for Run 11

